

Status of the development of Delhi Light Source (DLS) at IUAC

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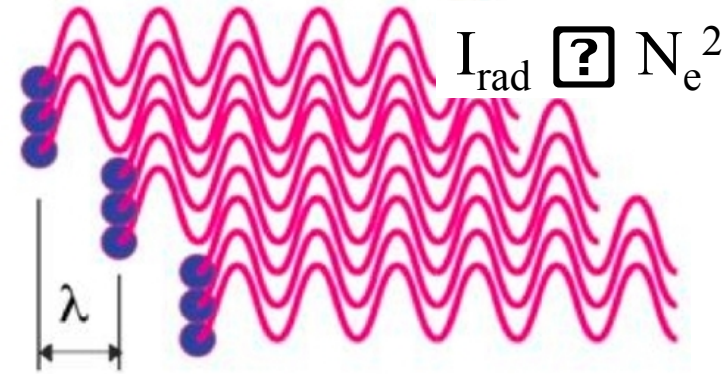
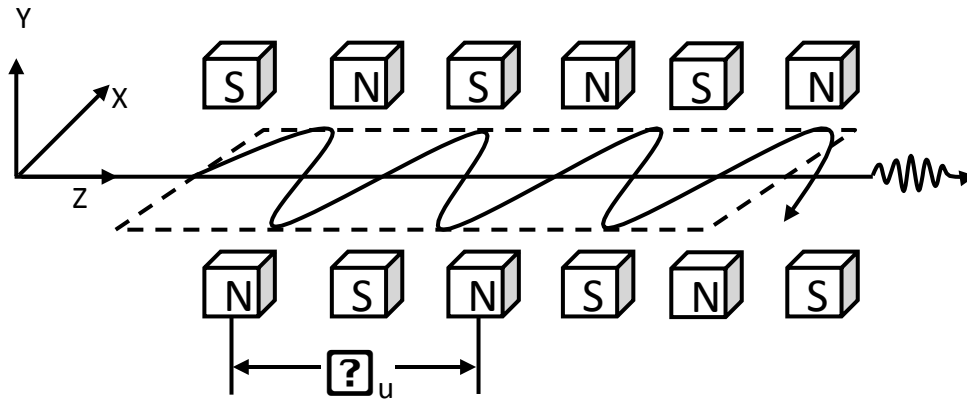


DELHI LIGHT SOURCE (DLS)

Plan of Presentation

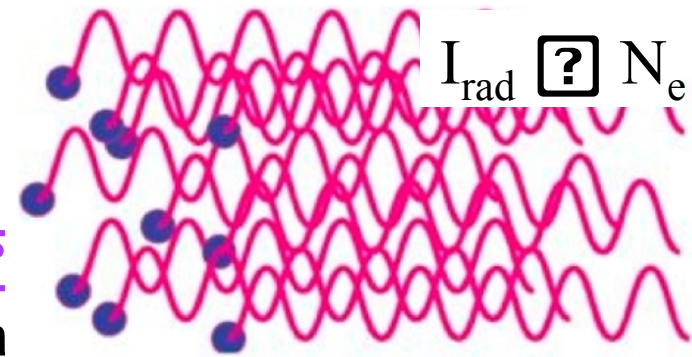
- Short introduction to Free Electron Laser (FEL)
- Pre-bunched FEL (DLS) & how is it different from conventional FEL
- Developments of Phase-I of DLS in Collaboration with KEK, Japan and HZDR, Germany
- Time chart
- Conclusion

Conventional FEL



Major points:

- Relativistic electron
- Approaching Undulator magnet, $[?]_U$
- $[?]_U$ - length contracted to $[?]_U^* = [?]_U/[?]$, $[?]$
- $[?]_U^*$ = Emitted wavelength from the electron
- Wavelength (lab fr.) = $[?]_R = [?]_U^*/2[?] = [?]_U/2[?]^2$, relativistic Doppler
- Including the parameter of Undulator, wavelength measured will be



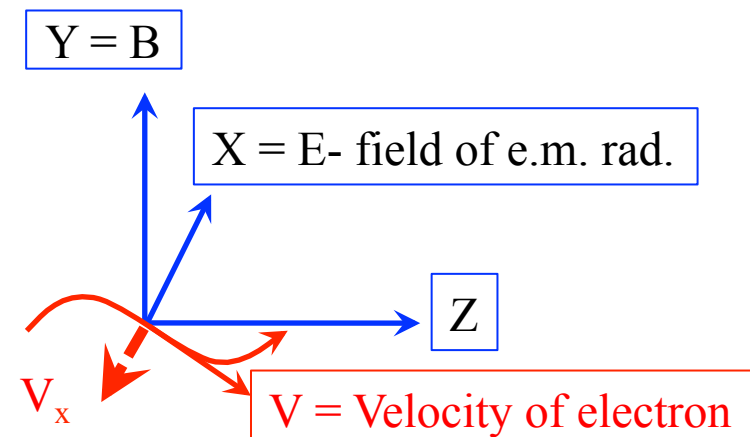
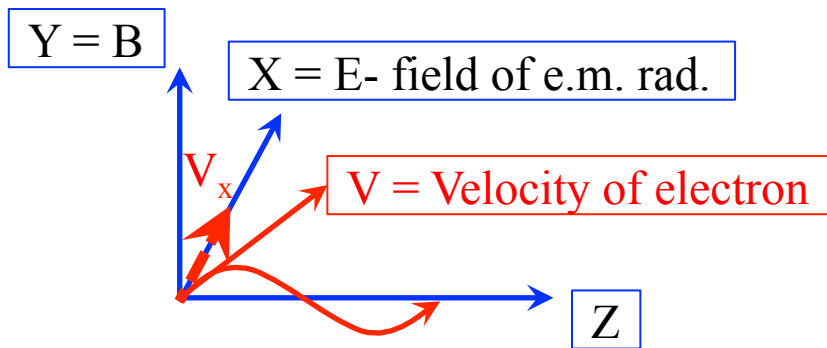
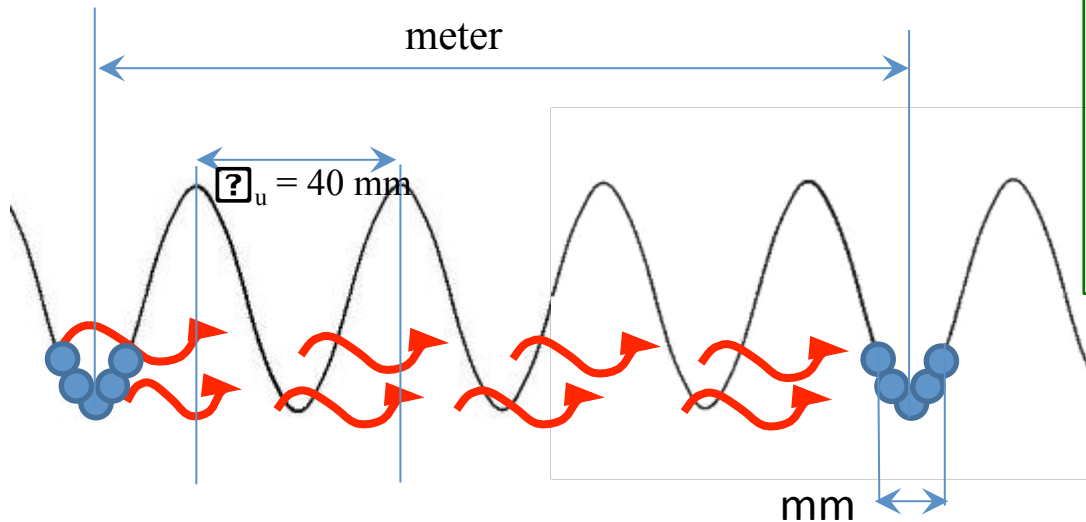
$$\lambda_R = \frac{\lambda_U}{2\gamma^2} \left[1 + \frac{K^2}{2} \right] \text{ where } K = 0.934 B u(T) \lambda_U(\text{cm})$$

Electrons radiate spontaneously, now coherence is to be established

How Coherent radiation is produced in FEL

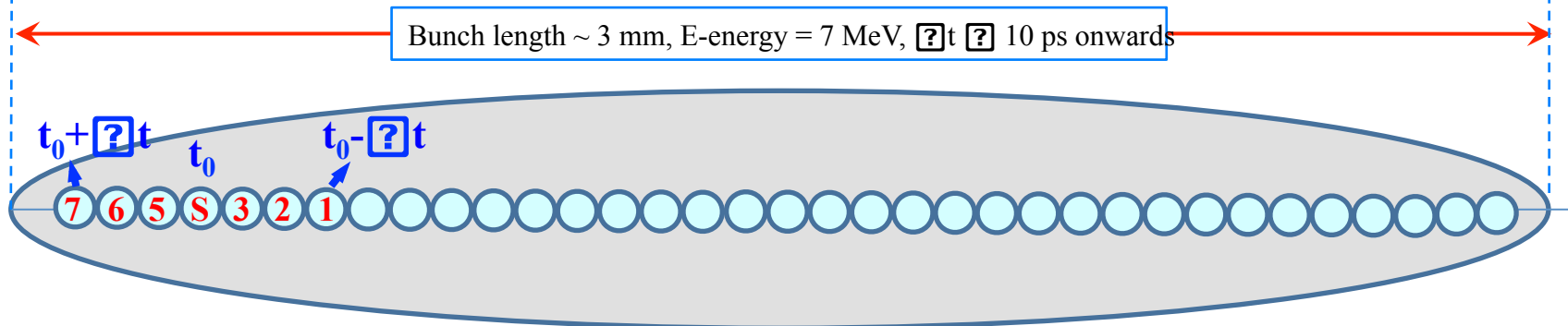
Electron velocity close to c
 E-beam bunch length \sim mm (ps)
 E-beam bunch separation \sim meter (MHz)

- ❖ Results to accl / decel of electron
 → Velocity modulation
- ❖ Electron are injected in bunches.
- ❖ Each bunch will be split in to microbunches due to velocity modulation.
- ❖ Process is known as
Microbunching

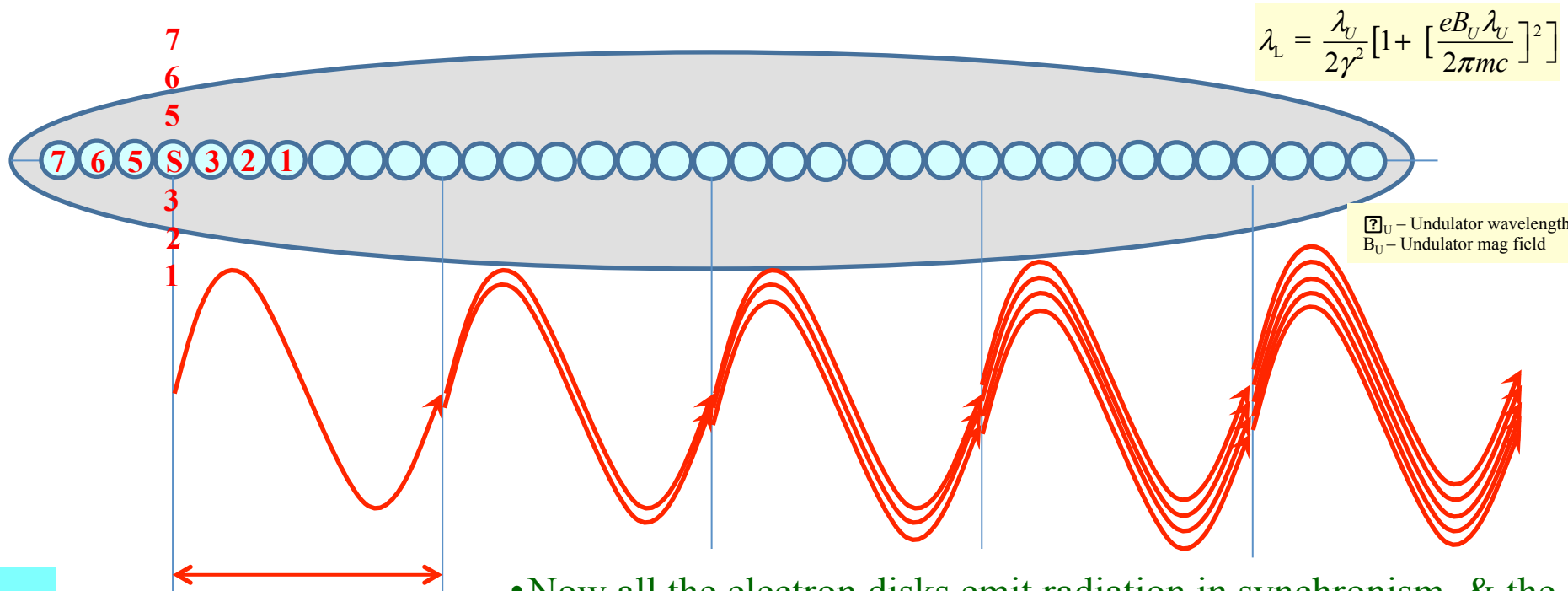


How Coherent radiation is produced in FEL

– Concept of SASE and Microbunching



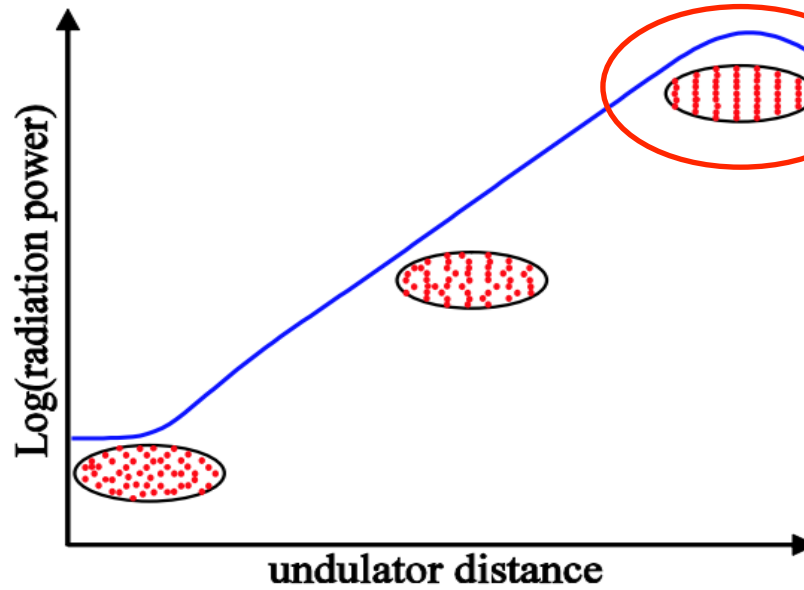
Interaction of Photon and wiggling electron inside undulator magnet



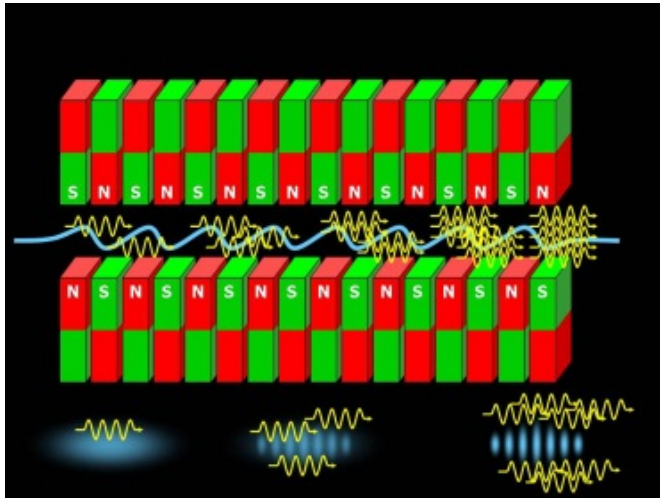
- Now all the electron disks emit radiation in synchronism, & the light can amplify itself to form high-intensity laser radiation.

λ_U = wavelength of radiation

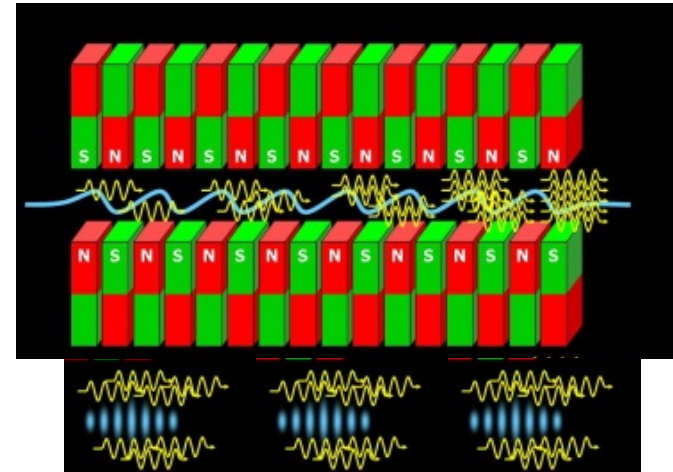
Pre-bunched FEL - How is it different from conventional FEL



Starting point of
Delhi Light Source



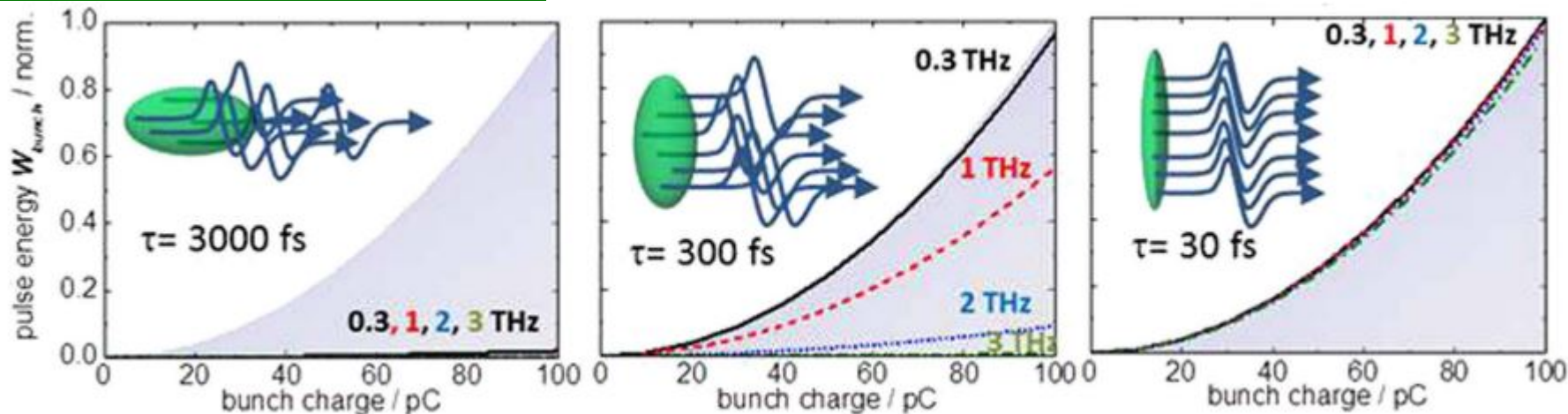
Conventional FEL



Prebunched FEL (Phase-I of DLS)

Super-radiant radiation from microbunch train

Super-radiant radiation



Superradiant radiation* – to produce frequencies when it is $\ll 1/[\tau]$ [$1/30 \text{ fs} = 33.3 \text{ THz}$]

If the time width of the electron beam bunch is $\sim 100 \text{ fs}$, then $1/[\tau] = 10 \text{ THz}$

Delhi Light Source (DLS): Super-radiant with microbunch train

- e-bunches which is few hundred of fs (200 fs) – super-radiant ($I \propto N_1^2$)
- In addition, train of microbunches (separation $\sim 500 \text{ fs}$ to a few ps) will be produced
- So $I \propto (N_1 + N_2 + \dots + N_{16})^2$

* B.Green et. al. [www.nature.com/scientificreports\(6:22256,DOI:10.1038\)](http://www.nature.com/scientificreports(6:22256,DOI:10.1038))

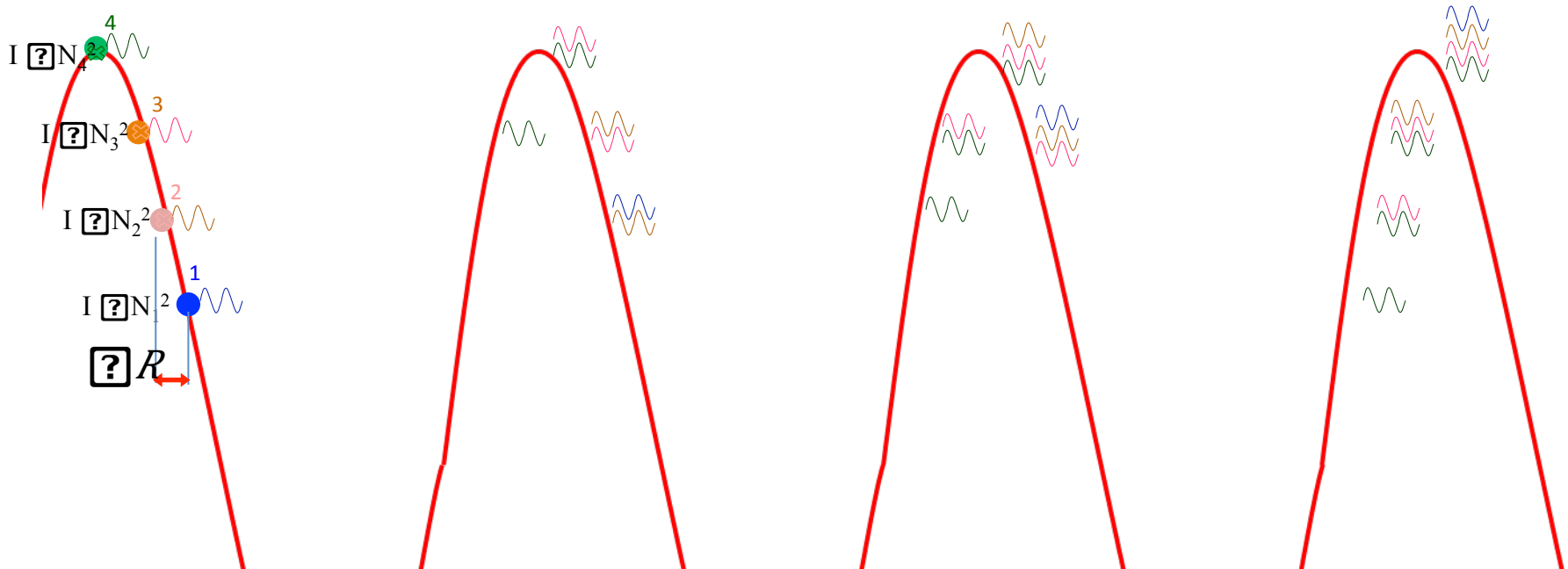
Where Photon meets Electron

$$R = U/2 \sqrt{1 + K^2/2}$$

U

$$v_z = c \sqrt{1 - (1 + K^2/2) / (U/c)^2}$$

$$U/c = U - R/v_z \text{ or } U$$

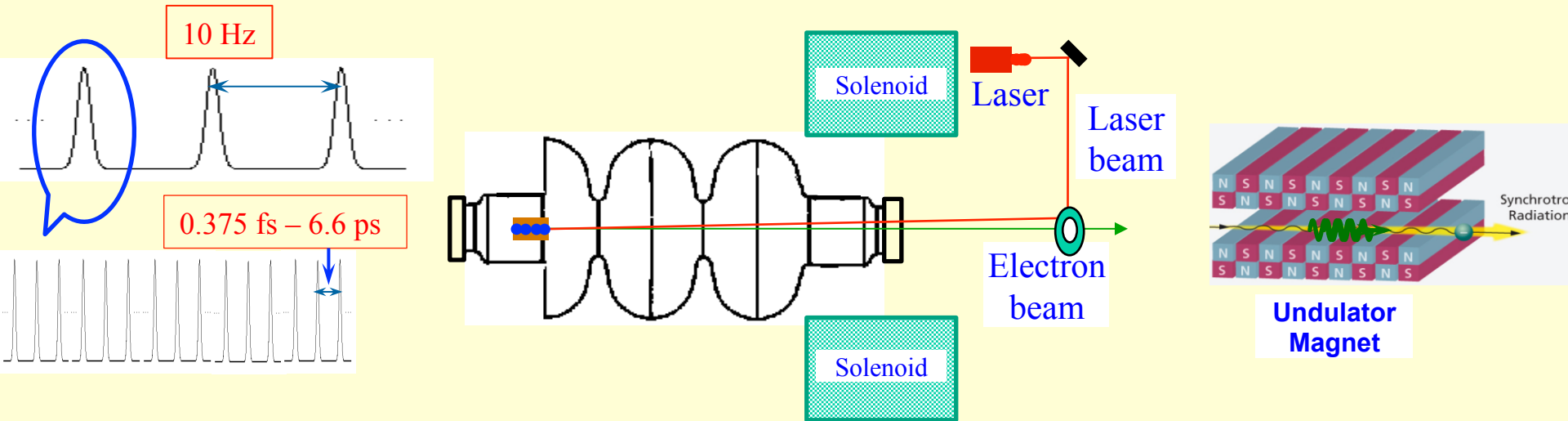


freq (THz)	Energy (MeV)	K_undulator	Longitudinal Velocity of electron (v_z) m/sec	Undulator wavelength (m)
0.15	4	2.982	2.8667E+08	0.045
0.6	6	2.032	2.9667E+08	0.045

$$I \propto (N_1 + N_2 + N_3 + N_4)^2 \text{ or } I \propto N^2$$

After 7 U , 4 photon bunches with I @ separation of R are emitted & will

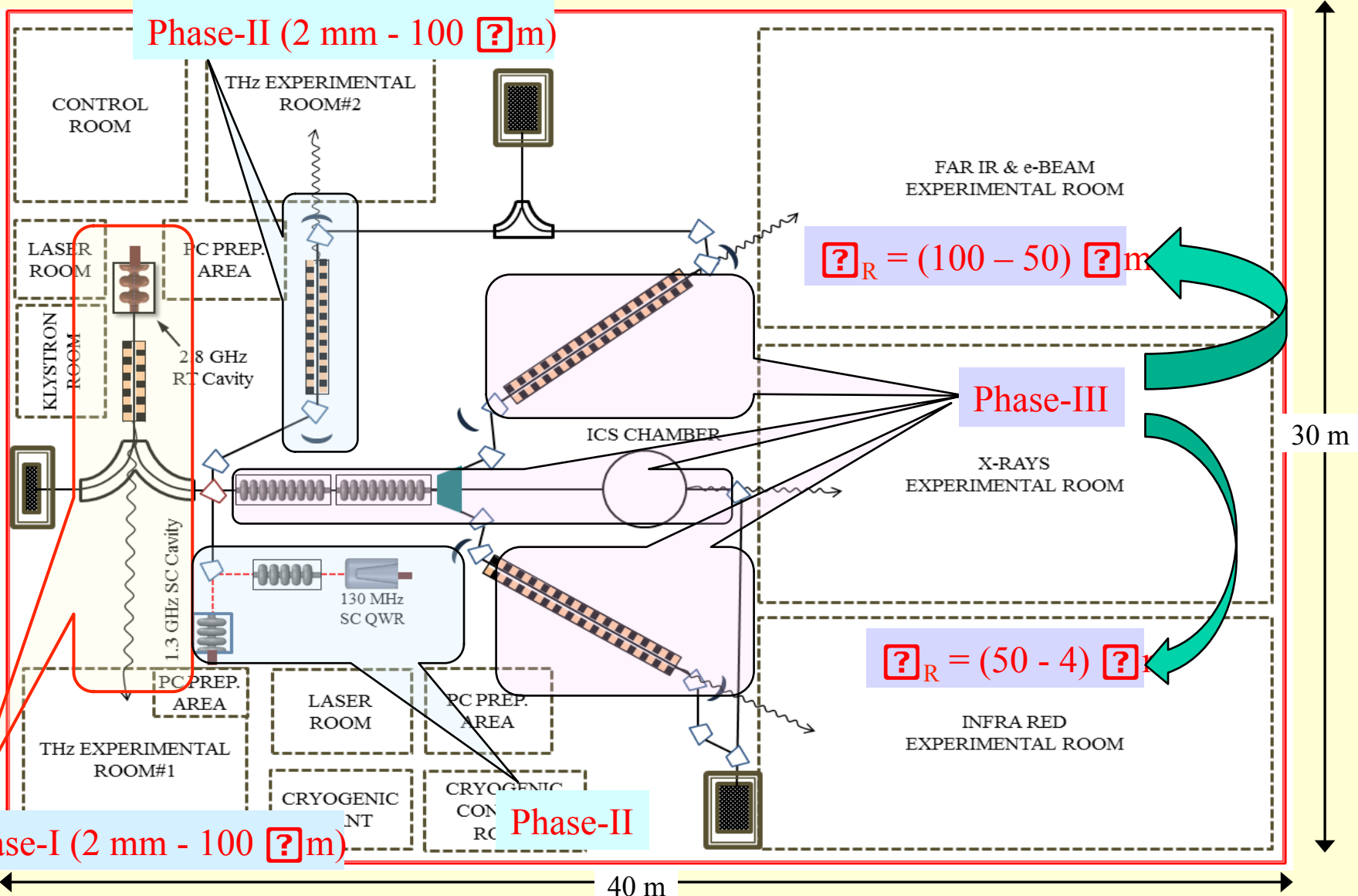
Major components of DLS (Phase-I) – Pre-bunched FEL



1. An electron gun – laser operated PC & a resonator powered by klystron/modulator
2. A laser system – produce the electron bunches – single pulse is split into many
3. Photocathode preparation device
4. Solenoid – focus electron beam – Cavity to Undulator
5. An Undulator magnet – to produce e.m. radiation
6. Beam diagnostic and e.m. radiation detector systems
7. Electronics and Control system

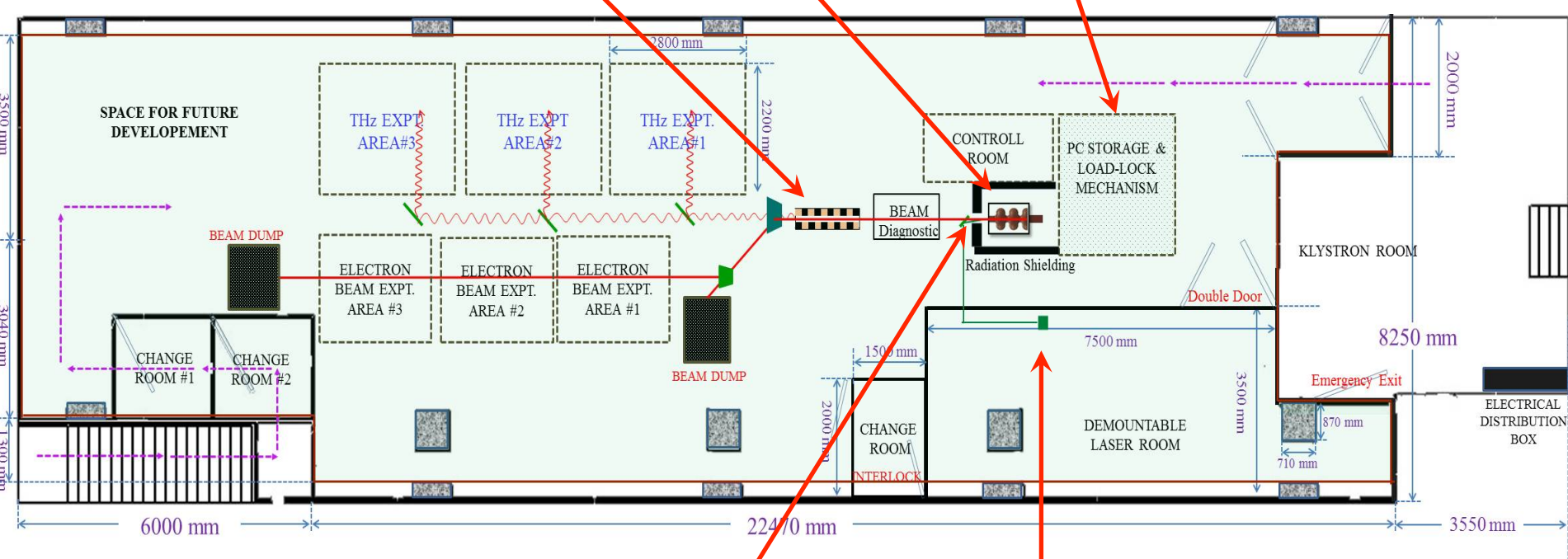
INTRODUCTION TO DELHI LIGHT SOURCE (DLS)

Layout of Delhi Light Source (DLS)



Phase-I of the project: complete layout with expt. stations

Undulator Cavity Photocathode Deposition Mechanism



Class 10000 clean room Existing concrete pillars

Solenoid Laser Device



Development of Phase-I

Physics Design

- Wavelength to be produced
- E-beam energy
- Beam optics design

Beam optics design is ready
Being validated

Choice of Accel. Components

- RF cavity, Frequency
- Photocathodes
- Laser
- Klystron, Modulator
- Solnd, Undulator, etc.

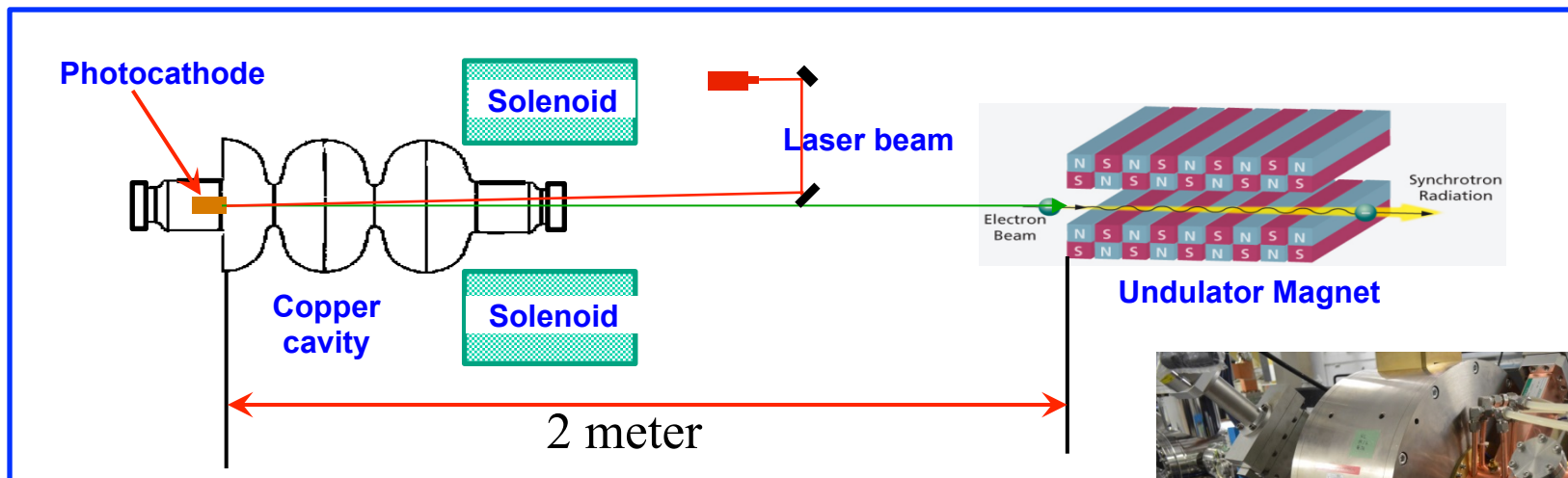
RF cavity – waiting to be installed
Photocathodes – Design frozen, tender preparation
Laser – Parameter finalized, development w KEK
Klystron, Modulator – Order to be placed – Oct '16
Solnd, **Undulator**, etc. – Tender floated, **Designing**

Electronics and Control

- For RF cavity & Time synchro syst
- For Diagnostics & Meas. System
- Control system

- Preliminary design
- Collaboration w BARC
- Components being procured

Beam optics calculation of Phase-I



1. Photocathode
2. Cavity
3. Solenoid
4. Undulator

Parameters at cathode:

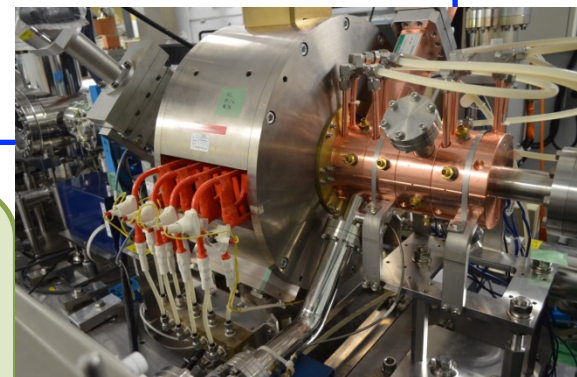
- Laser spot size
- Bunch emission time
- Charge/e-bunch
- Initial transverse emittance

Parameters at rf gun and solenoid:

- Laser injection phase (RF phase what electron sees at the photocathode)
- Max possible E field of gun
- Optimize B field of Solenoid

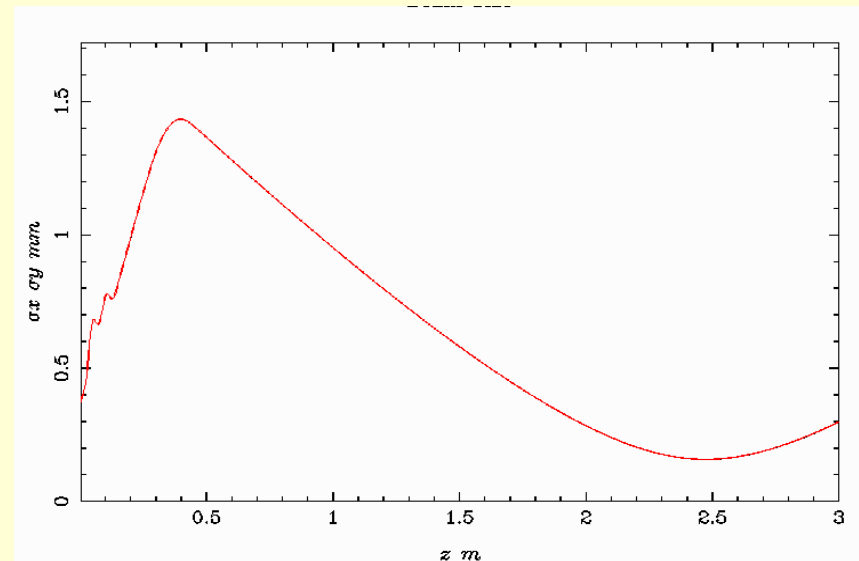
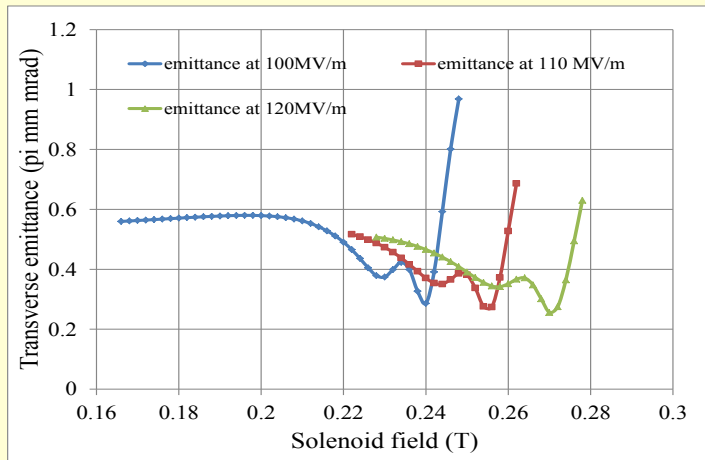
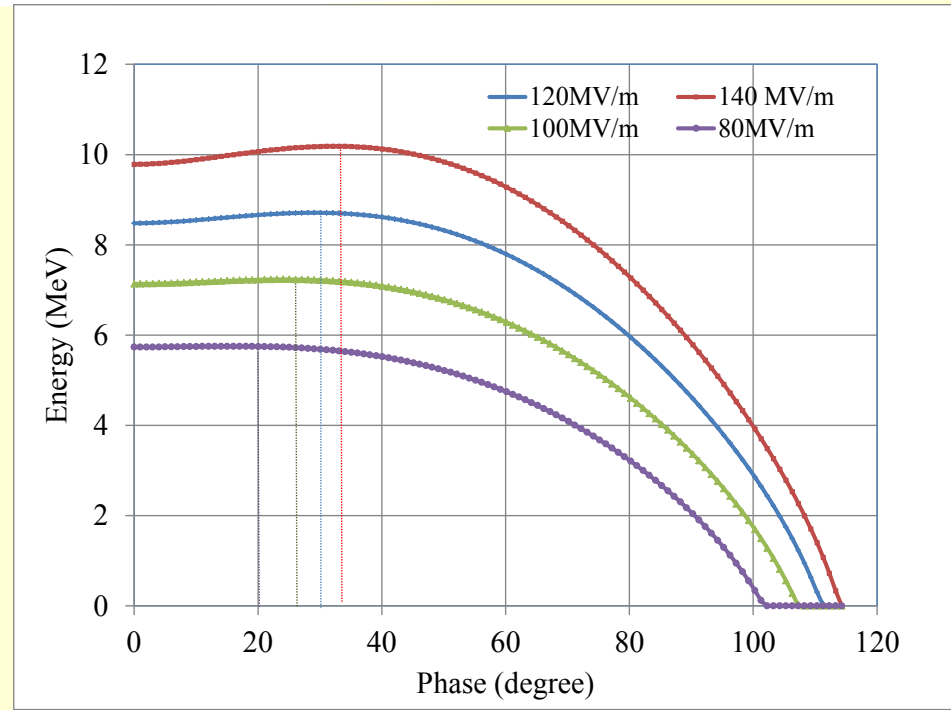
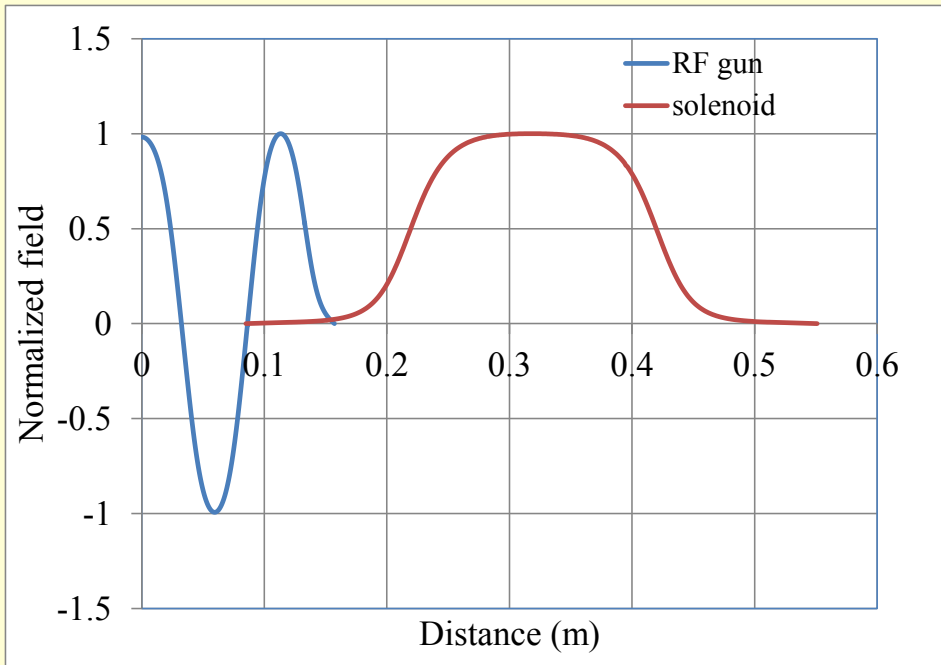
Results (important parameters):

- Transverse emittance
- Spot size
- Bunch time spread
- Energy
- Energy spread



Beam optics calculation

Calculation with single bunch



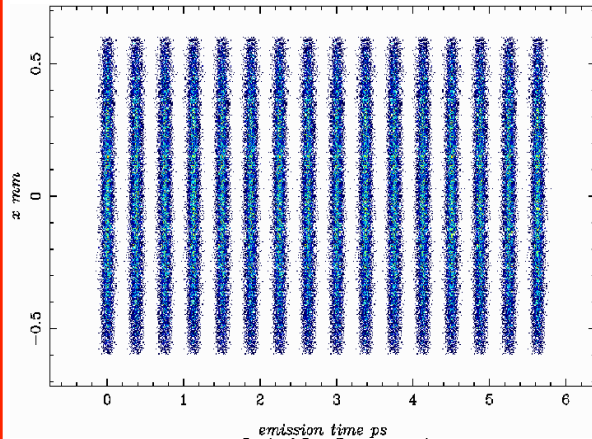
Beam optics calculation

Energy of electron beam ~ 8.5 MeV
Microbunch FWHM at cathode: 100 & 300 fs
Microbunch separation at cath.: 375 & 800 fs

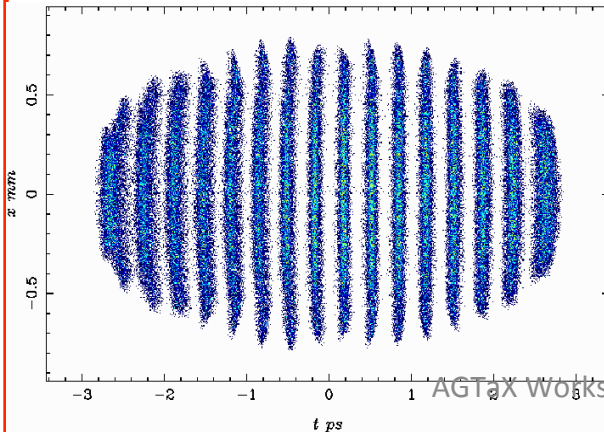
Cavity field: 120MV/m
Solenoid field: 0.273 and 0.270T
Injection phase: 35 degree

6 pC, FWHM/Sep - 100/375 fs

At Cathode

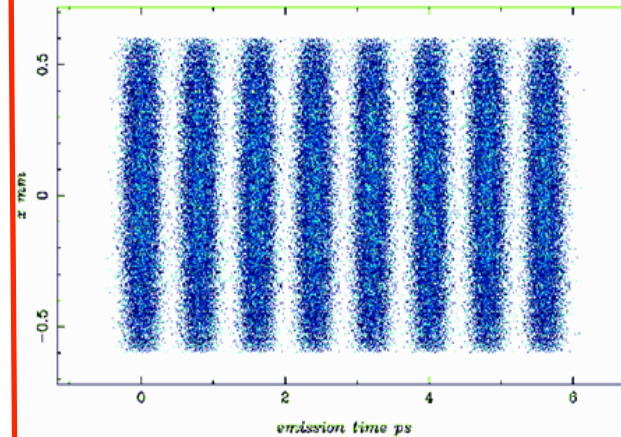


At 2.4 meter

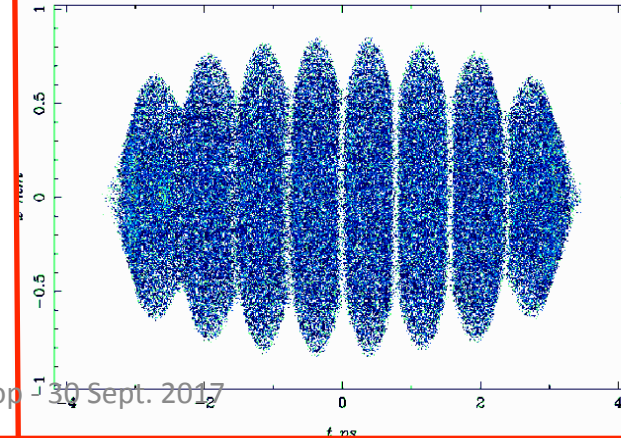


25 pC, FWHM/Sep - 300/800 fs

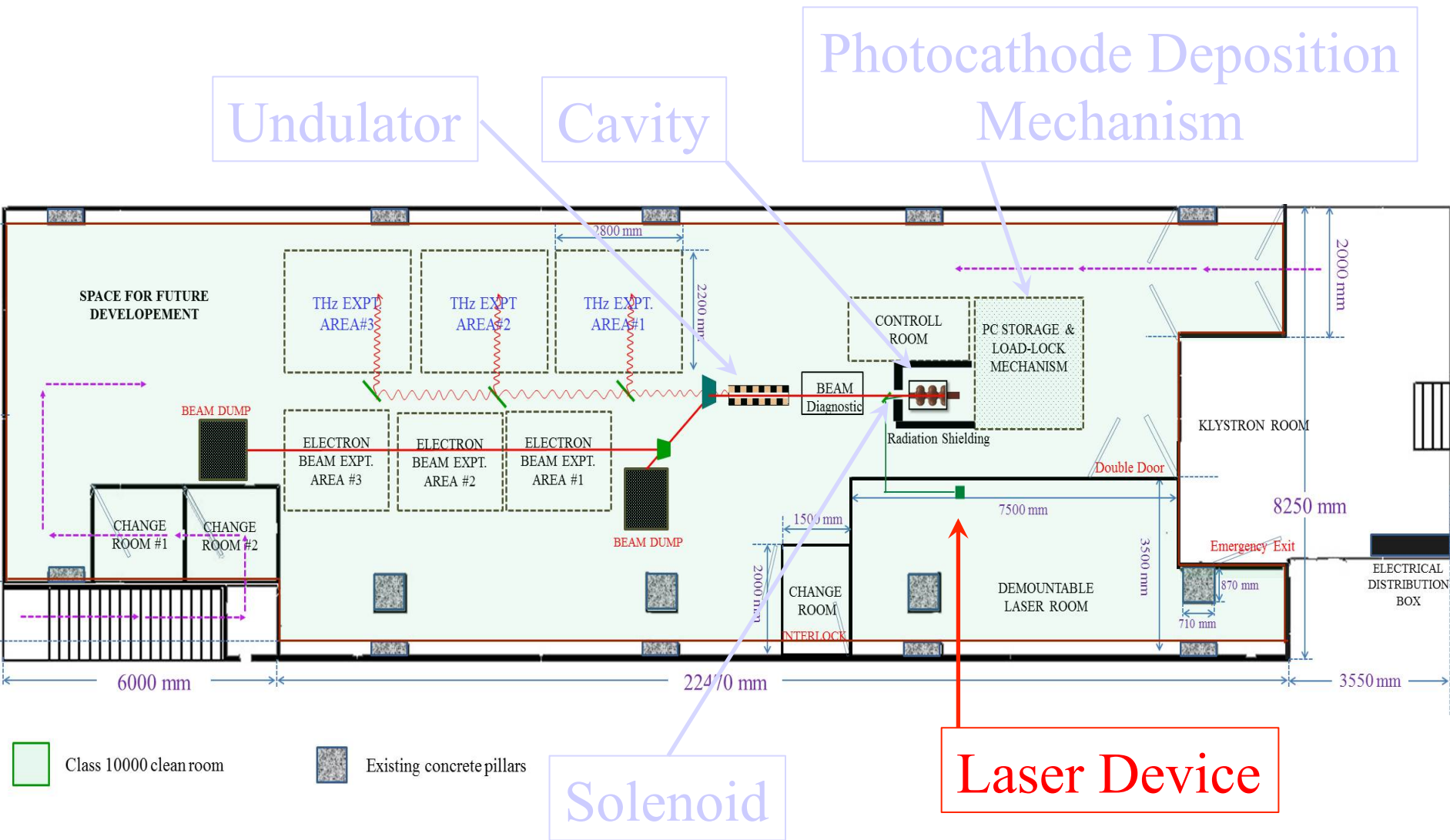
At Cathode



At 2.4 mts

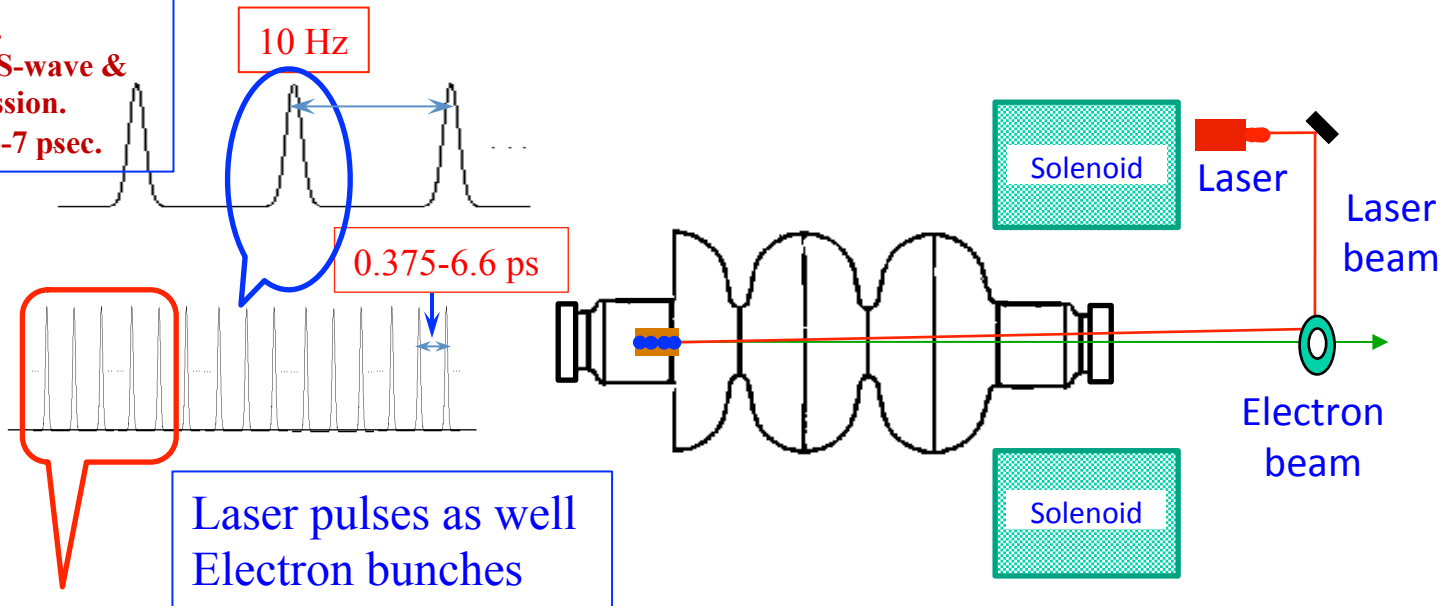


Phase-I of the project: complete layout with expt. stations

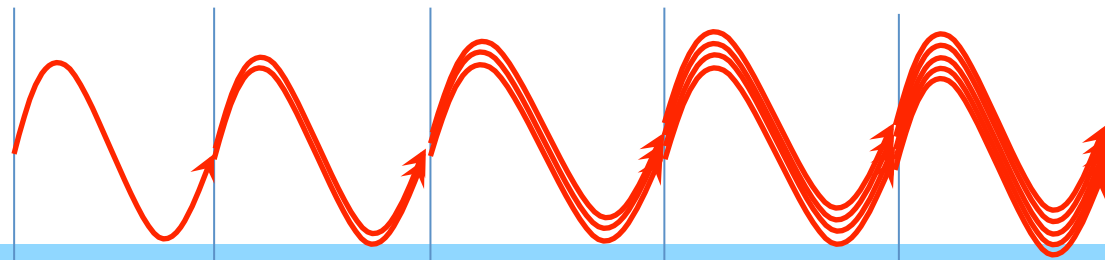
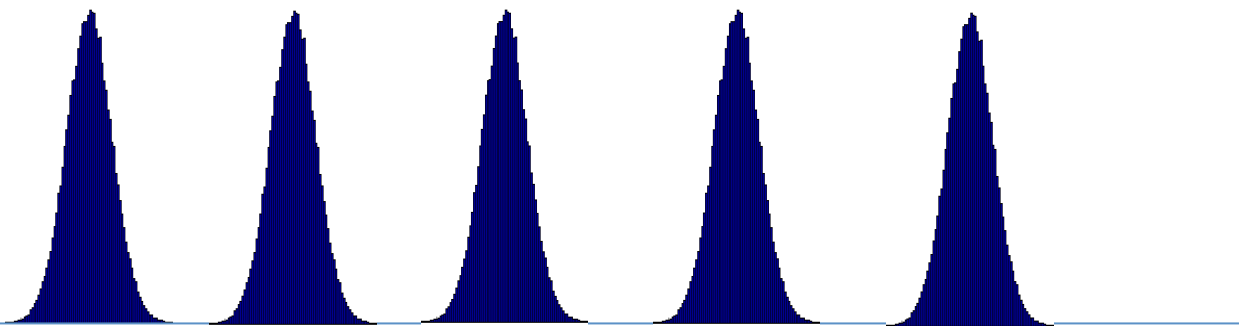


Laser system of Phase-I of DLS

- $\frac{1}{2}$ w plate rotates S-wave by 45° .
- Polarizing beam splitter makes S-wave & P-wave by reflection & transmission.
- 16 micro bunched laser within 6-7 psec.



$f \sim 3 - 0.15$ THz
 $T = 0.375$ ps to 6.6 ps
 $\lambda = 112$ nm to 2 mm



$$\lambda_R = \lambda_U / 2 \gamma^2 [1 + K^2]$$

$$\gamma = E / E_0 = 8 / 0.5 = 16$$

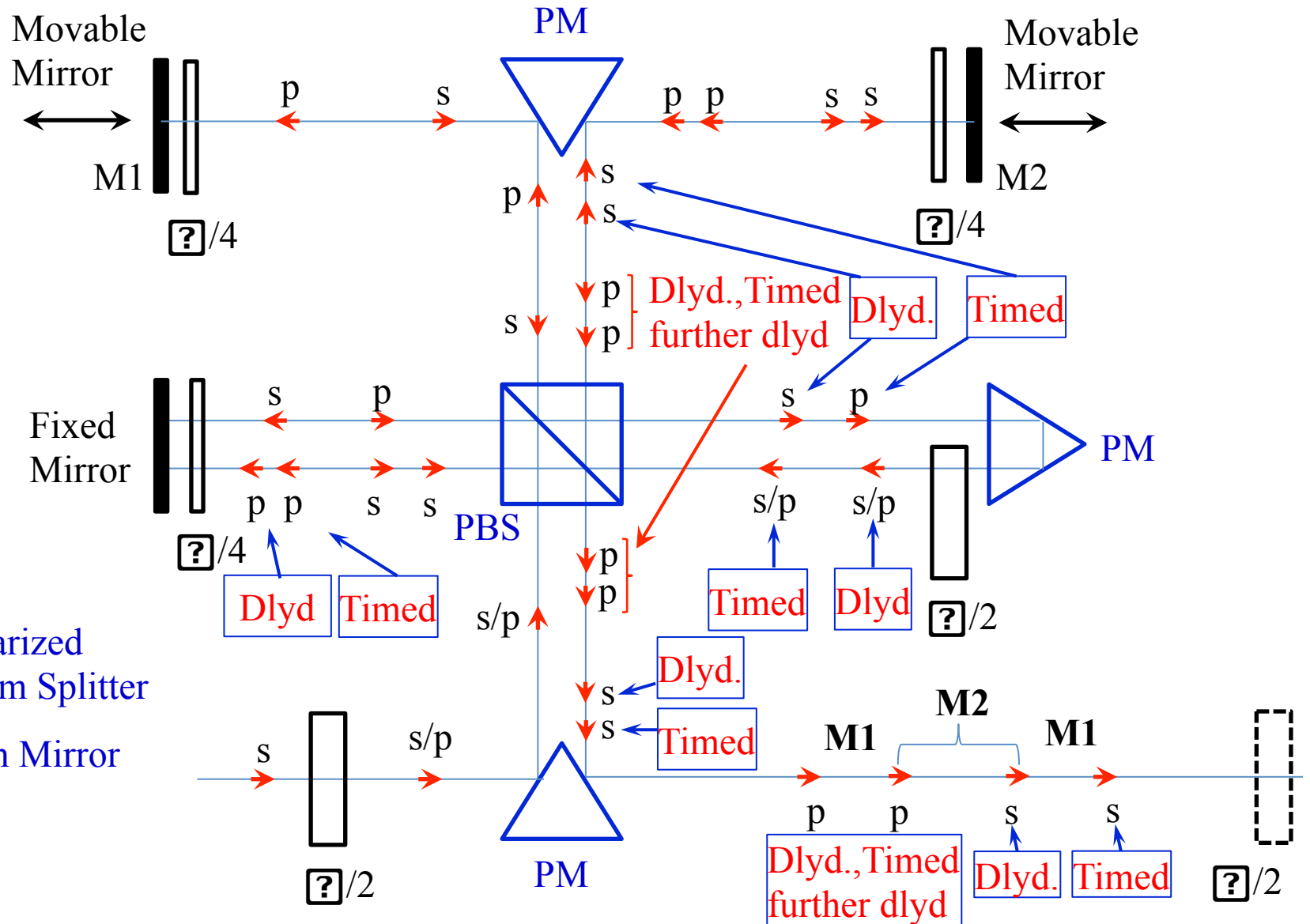
λ_U – Undulator wavelength
 B_U – Undulator mag field



Principle of splitting a single laser pulse in to many pulses



A single laser pulse is split in to four laser pulses with variable separation



Available laser power vs. Beam optics requirement

Laser Specification

Beam optics Calculation

System	Energy/ pulse (UV)	Cathode	No of Microbunches	Available charge/ pulse	No. of Microbunches and Charge per microbunch	Laser system meet the requirement	Pulse width (fs)	Separation between microbunches (fs)	Frequency of THz to be produced
TANGERINE (Fibre)	30 [?]J	Cu	2, 4, 8 & 16	28, 12, 4.5, 2.3 pC	8 no, 4 pC	Yes	~300	700	1.4 THz
		Cs ₂ Te	2, 4, 8 & 16	13, 6, 3, 1.5 nC	8 no, 6 pC	Yes	~ 300	700	1.4 THz
S-Pulse 2 (Hybrid)	200 [?]J	Cu	2, 4, 8 & 16	190, 84, 37, 15 pC	4 no, 35 pC	Yes	~ 500	1200	0.83 THz
		Cs ₂ Te	2, 4, 8 & 16	95, 42, 18, 8 nC	4 no, 80 pC	Yes	~500	1800	0.55 THz
Ti:Sa (Solid State)	1.5 mJ	Cu	2, 4, 8 & 16	1.4, 0.6, 0.3, 0.1 nC	16 no, 6 pC	Yes	~100	375	2.66 THz
		Cs ₂ Te	2, 4, 8 & 16	710, 315, 140, 60 nC	16 no, 6 pC	Yes	~100	375	2.66 THz
Fiber Laser assembled @ KEK	25uJ	Cu	2, 4, 8 & 16	23, 10, 3.7, 2 pC	16 no, 2 pC	Yes	~200	400	2.50 THz
		Cs ₂ Te	2, 4, 8 & 16	11, 5, 2.5, 1.2 nC	16 no, 6 pC	Yes	~200	500	2.00 THz

Available laser power vs. Beam optics requirement

Laser Specification						
System	Energy/ pulse (UV)	Cathode	No of Microbunch es	Available charge/ pulse	Equipments to be supplied	Tentative Price
TANGERINE (Fibre)	30 [?]J	Cu	2, 4, 8 & 16	28, 12, 4.5, 2.3 pC	Osc. + Amp. + Freq. Conv. + Synch. System (no splitting)	\$ 425,000
		Cs ₂ Te	2, 4, 8 & 16	13, 6, 3, 1.5 nC		
S-Pulse 2 (Hybrid)	200 [?]J	Cu	2, 4, 8 & 16	190, 84, 37, 15 pC	Osc. + Amp. + Freq. Conv. + Synch. System (no splitting)	\$ 360,000
		Cs ₂ Te	2, 4, 8 & 16	95, 42, 18, 8 nC		
Ti:Sa (Solid State)	1.5 mJ	Cu	2, 4, 8 & 16	1.4, 0.6, 0.3, 0.1 nC	Osc. + Amp. + Freq. Conv. + Synch. System (no splitting)	\$ 390,000
		Cs ₂ Te	2, 4, 8 & 16	710, 315, 140, 60 nC		
Fiber Laser assembled @KEK	25uJ	Cu	2, 4, 8 & 16	23, 10, 3.7, 2 pC	Osc. + Amp. + Freq. Conv. + Synch. System + splitting To be tested in KEK system	\$ 200,000
		Cs ₂ Te	2, 4, 8 & 16	11, 5, 2.5, 1.2 nC		

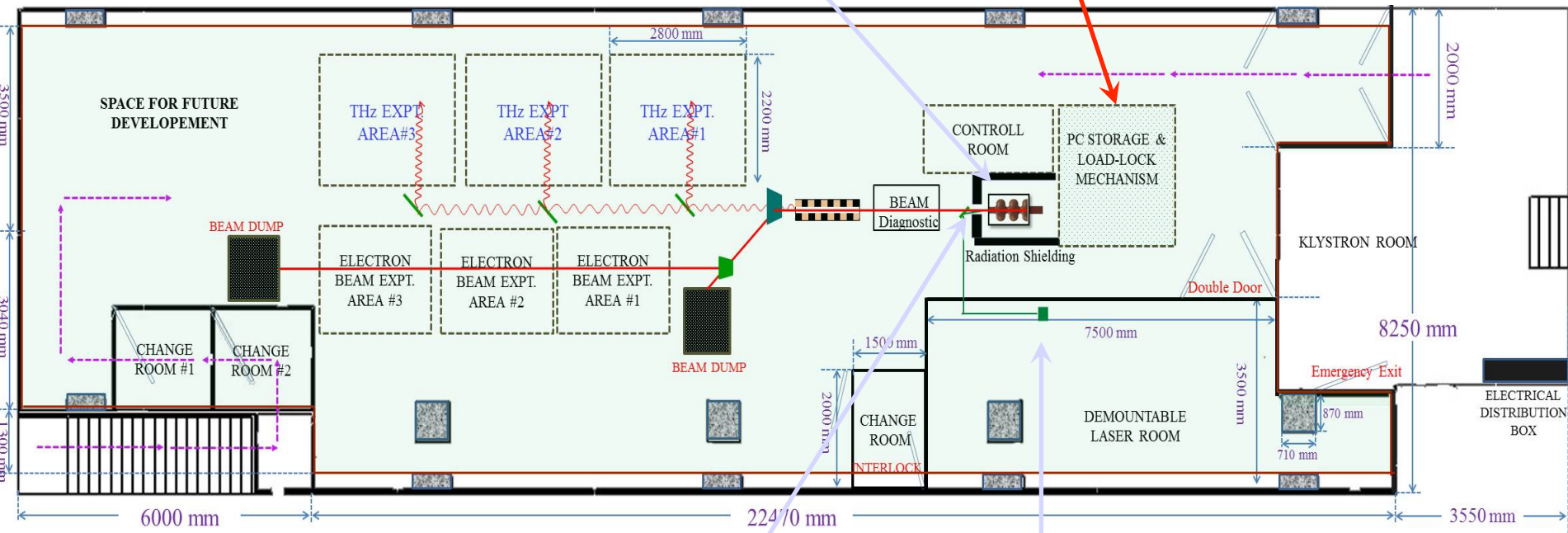
Phase-I of the project: complete layout with expt. stations

Photocathode Deposition Mechanism

Cavity

Solenoid

Laser Device



Class 10000 clean room Existing concrete pillars



Phase-I: RT e-gun

Details of Photocathode

Photocathode:

- Metal Photocathode e.g. Copper, Magnesium, Lead
- Semiconductor photocathode e.g. Cs₂Te, K₂CsSb, GaAs

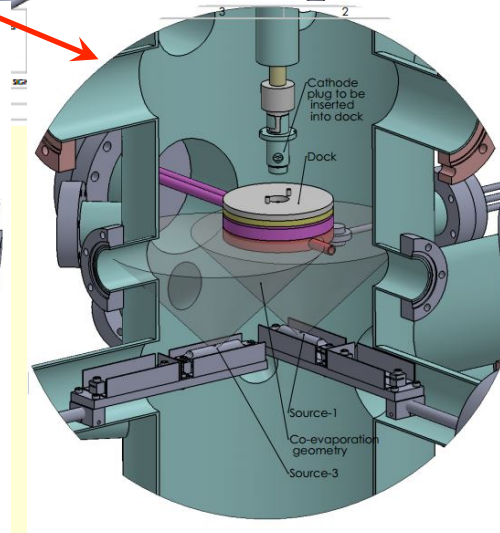
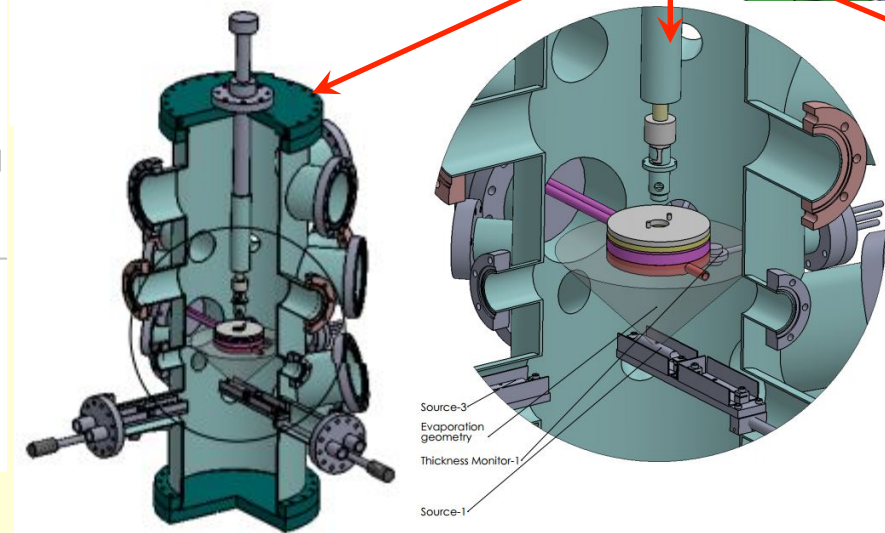
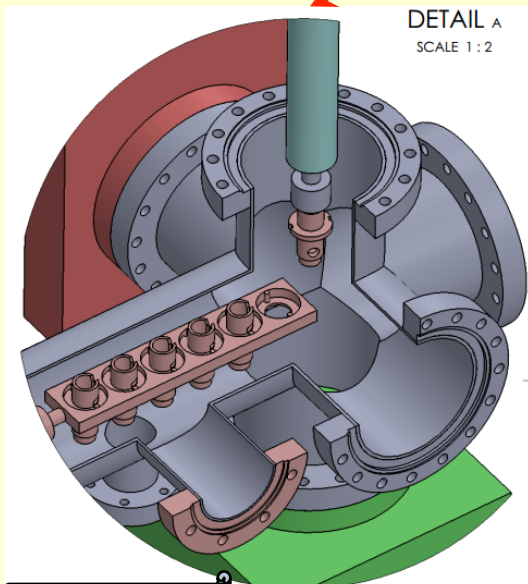
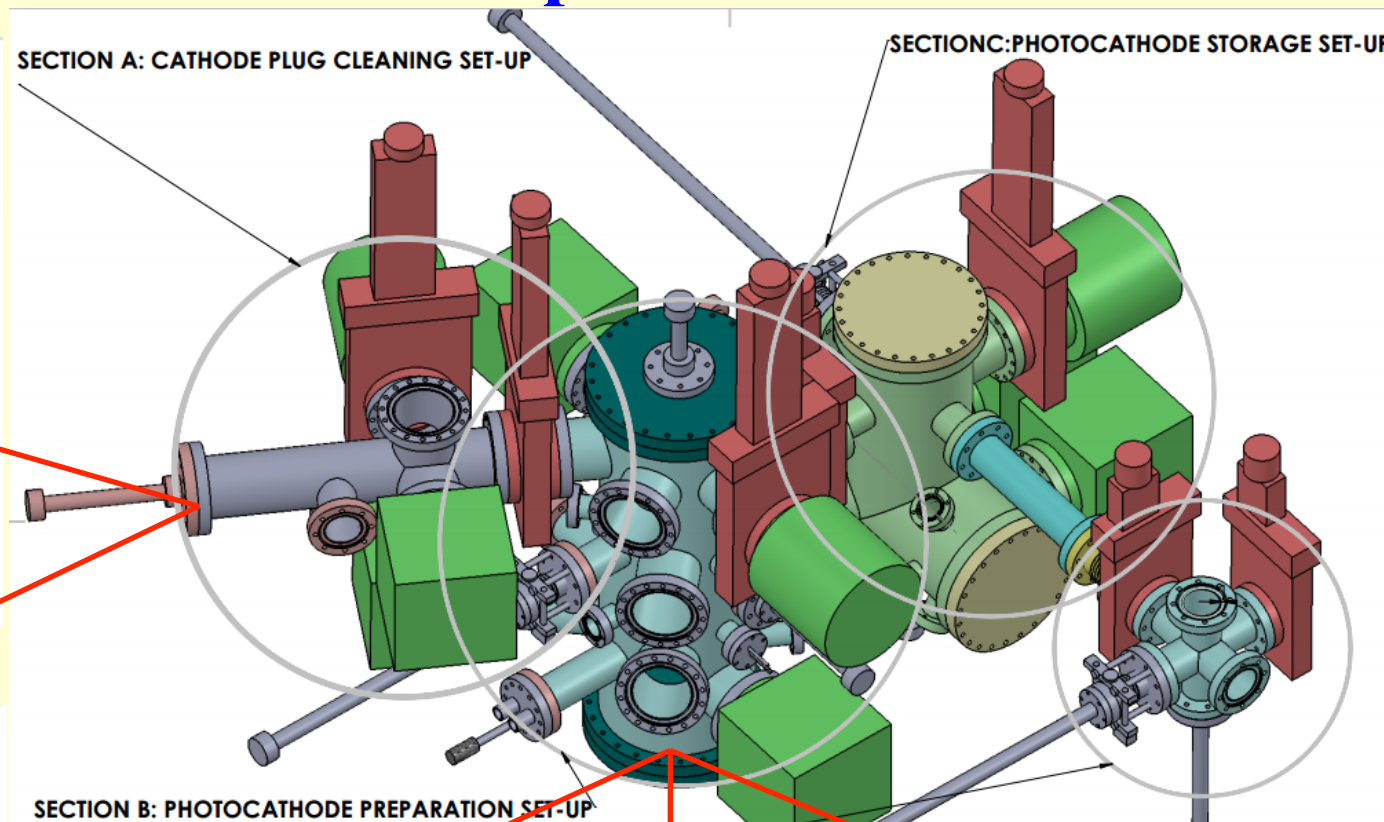
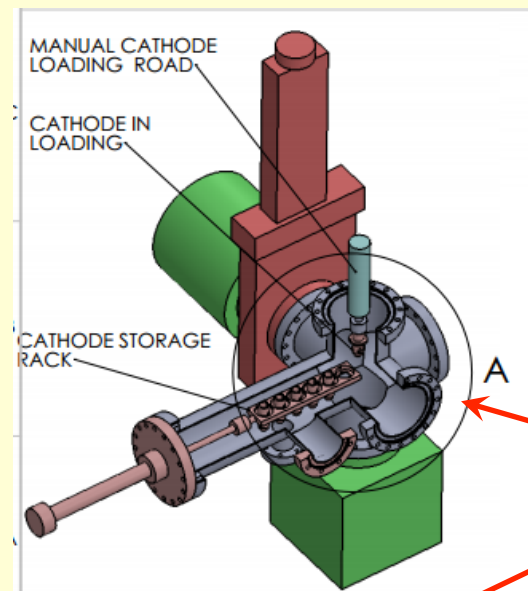
To be developed at IUAC



Cathode	Quantum Efficiency (%)	Photon Energy (eV)	Photon wavelength (nm)	Advantage	Disadvantage	Laser Energy for 1 nC/pulse (~ 10 ⁹ e/pulse)
Copper	0.014	4.96 eV	250	Rugged, Long life, Less vac	Less QE, High Laser energy	35.4 [?]J
Magnesium	0.62	4.66 eV	266			9.2 [?]J
Lead	0.016	5.8 eV	214			2.2 [?]J
Cs ₂ Te	~10	4.66 eV	266	High QE, Less laser Energy	Delicate, Shorter life, UHV	51 nJ
K ₂ CsSb	~10	2.33 eV	533			23.3 nJ
GaAs:Cs	~10	2.33 eV	533			23.3 nJ
GaN:Cs <small>Thin layer of Cesium is deposited on GaN</small>	~15	4.77 eV	260	V. High QE robust (thk ~ 100-1000nm), QE is 50% back after 200C vac bakeout	New PC, not much data av.	37 nJ

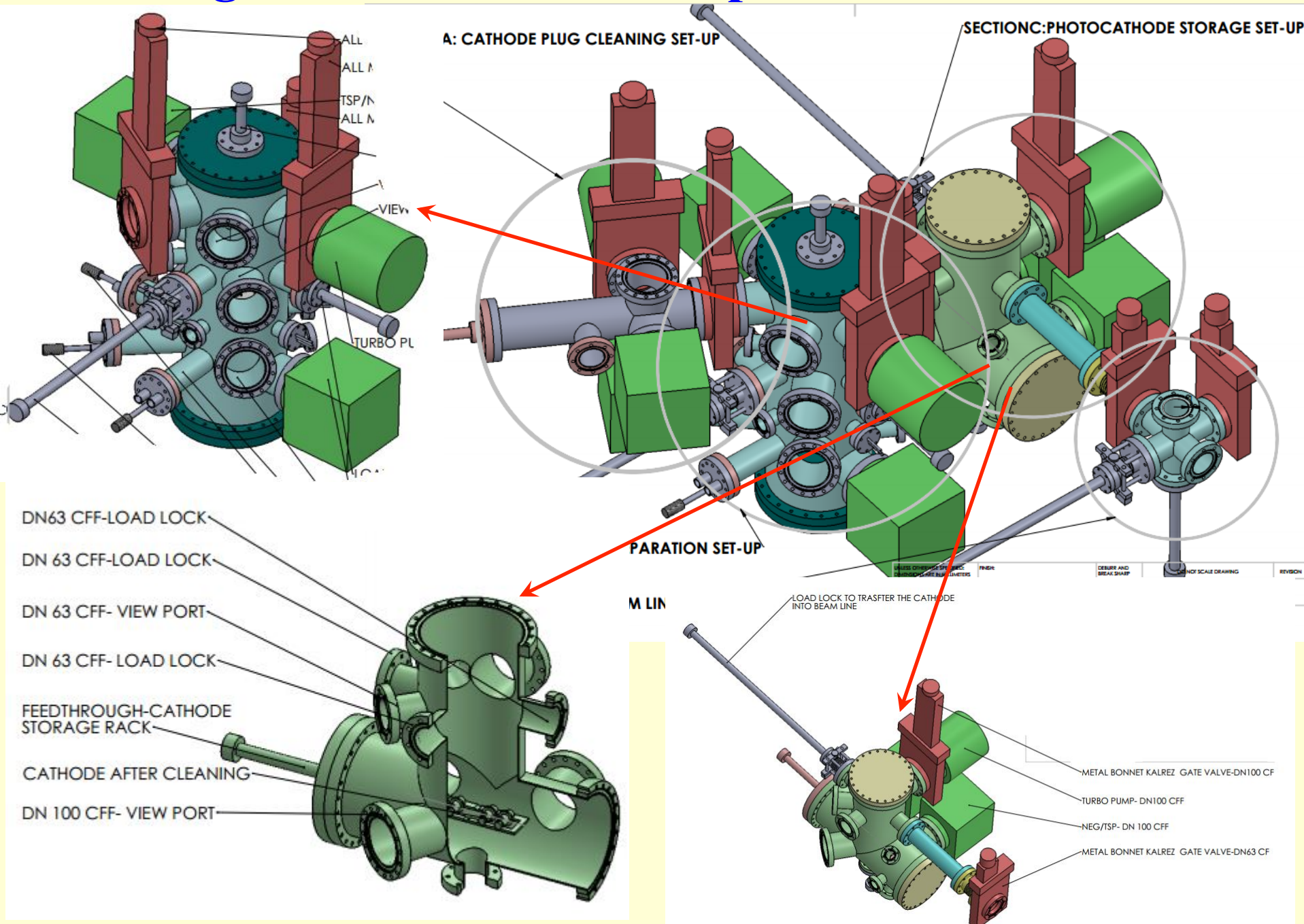
- Thickness of CsTe ~ 100 nm, surface roughness ≤ 10-20 nm

Design of Photocathode deposition mechanism

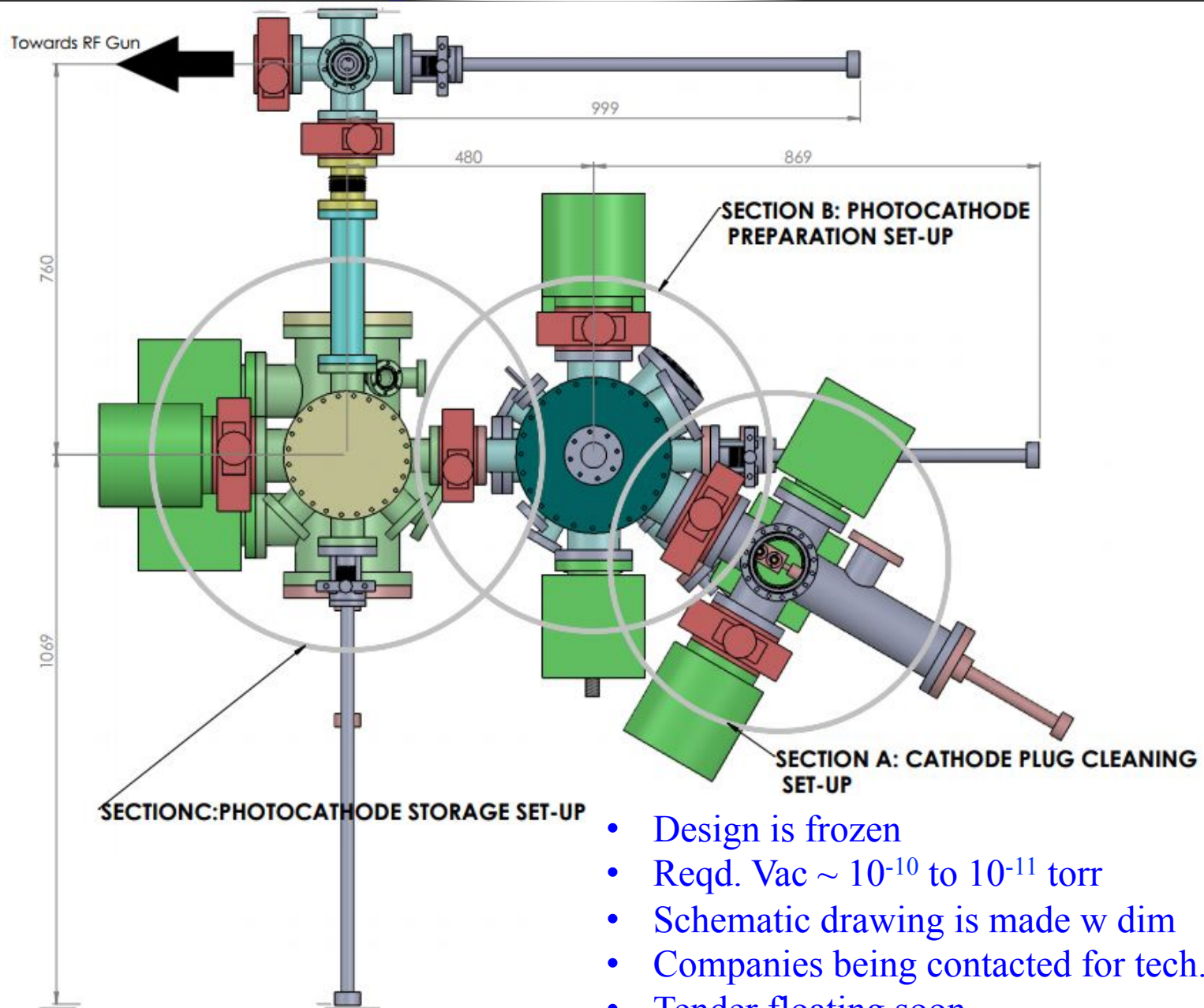


Video

Design of Photocathode deposition mechanism

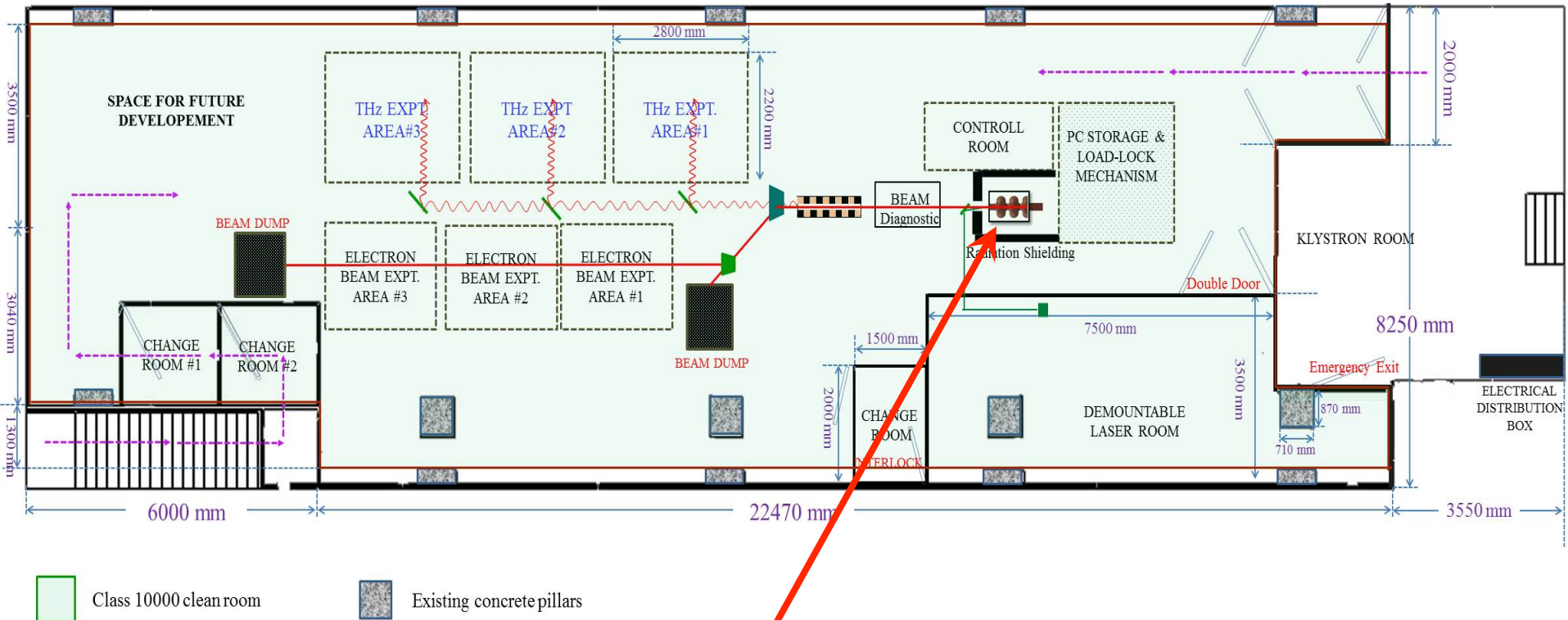


Development of Photocathode



- Design is frozen
- Req'd. Vac $\sim 10^{-10}$ to 10^{-11} torr
- Schematic drawing is made w dim
- Companies being contacted for tech. feedback
- Tender floating soon

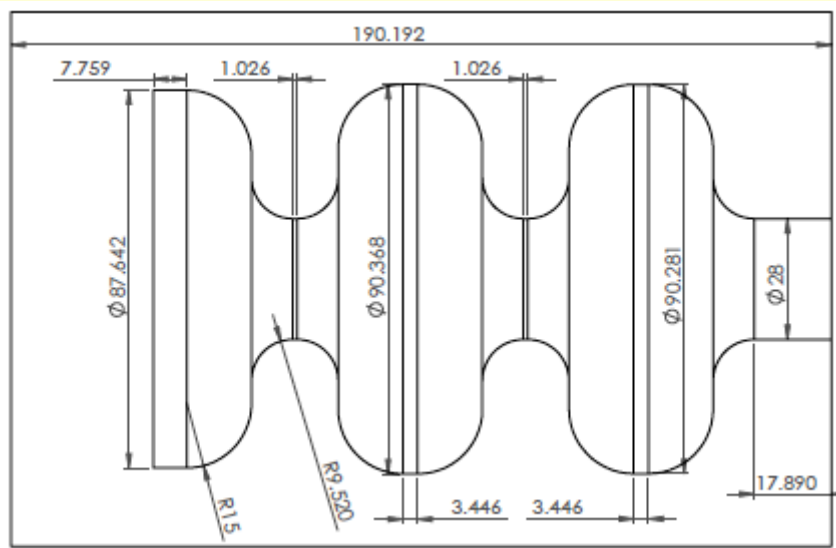
Phase-I of the project: complete layout with expt. stations




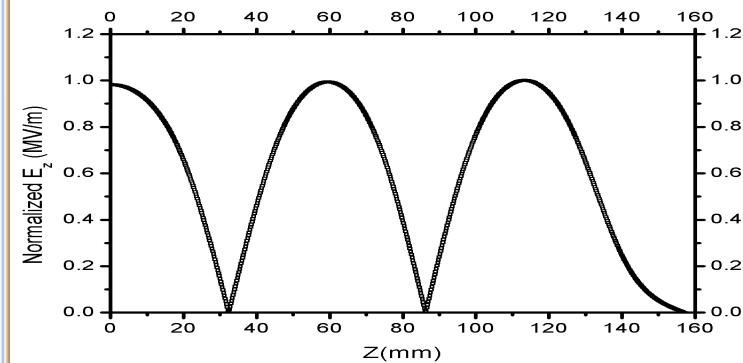
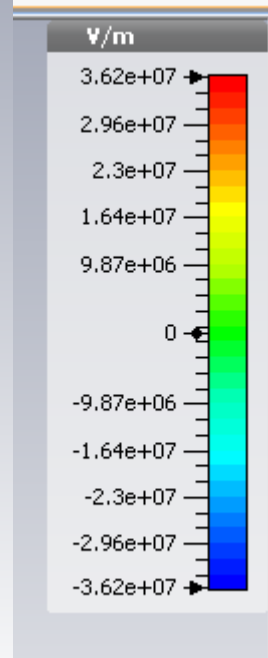
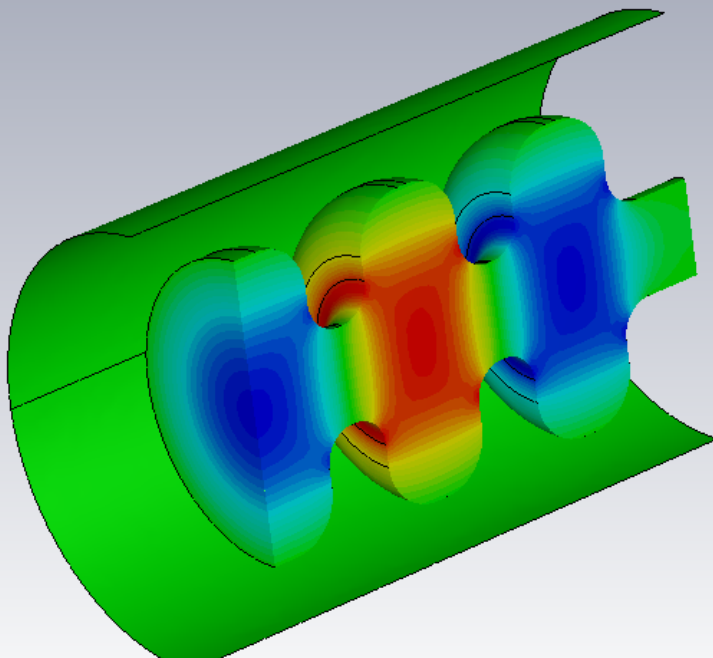
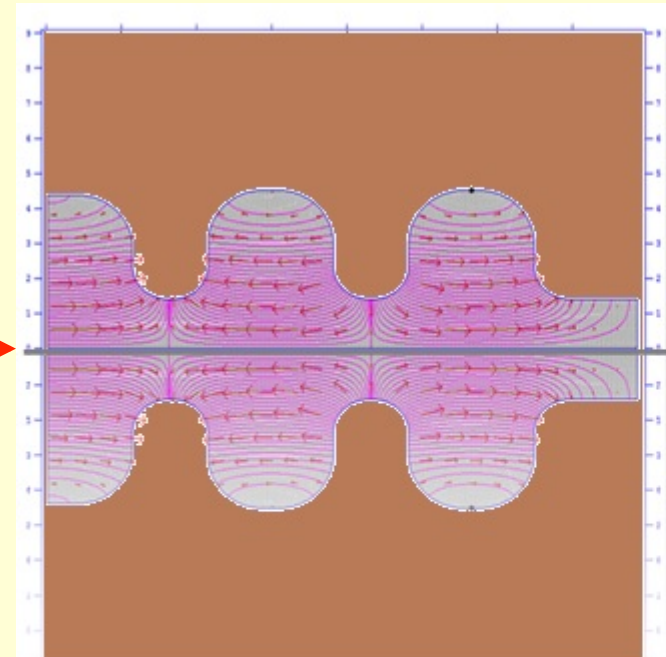
RF Cavity



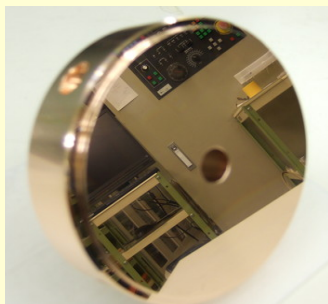
RF cavity as e-gun – Design and Simulation



Beam Axis 



RF cavity as the electron gun (fabrication at KEK)



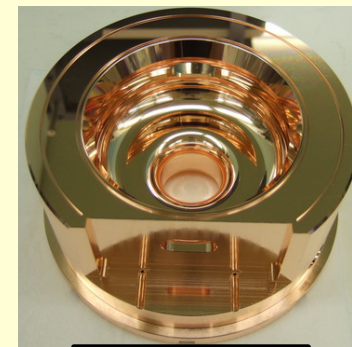
END PLATE



HALF CELL



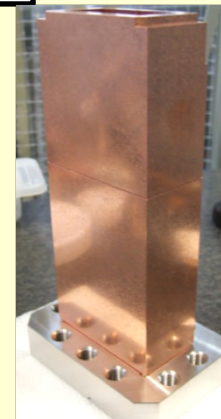
MIDDLE CELL



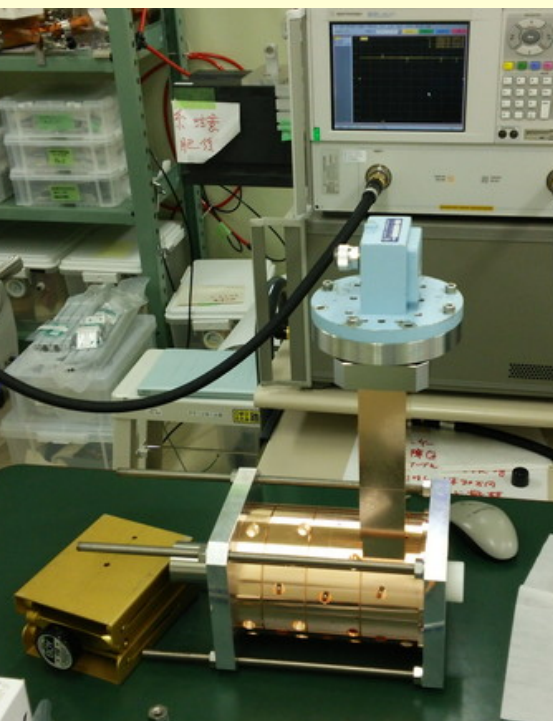
FULL CELL



FULL CAVITY

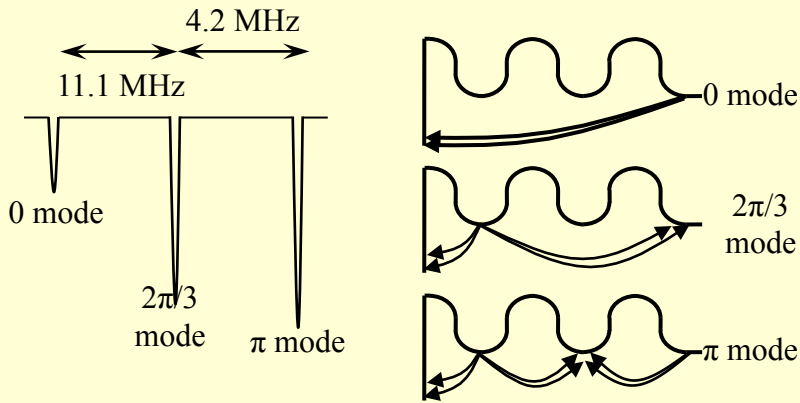


WAVE GUIDE

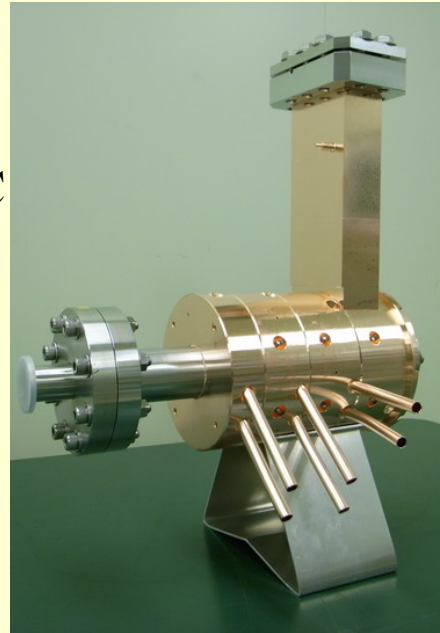


	m/c #1	m/c #2	m/c #3	m/c #4	m/c #5
radius – HC	43.370	43.71	43.83	43.85	43.85
radius - FC1	44.515	44.99	45.12	45.14	45.18
radius - FC2	44.515	44.84	44.91	44.95	45.14
[?] - mode	2902.503	2871.267	2862.742	2860.585	2859.747

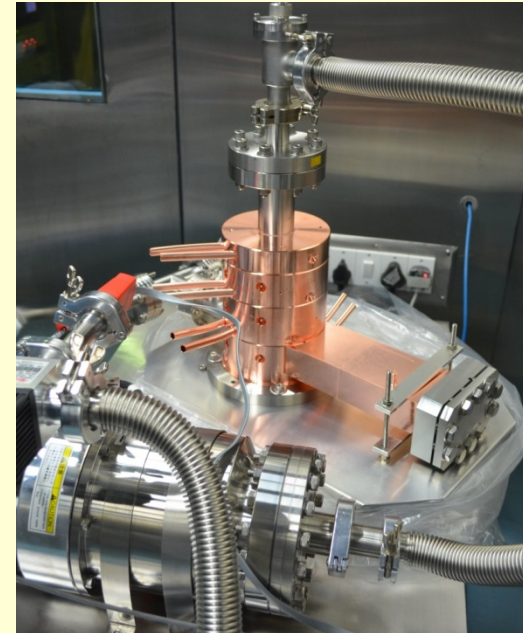
Final testing of the RF cavity



$$\frac{1}{Q_{\downarrow 0}} = \frac{1}{Q_{\downarrow L}} - \frac{1}{Q_{\downarrow ext}} = \frac{1}{7988} - \frac{1}{16822} \Rightarrow Q_{\downarrow 0} = 15211$$

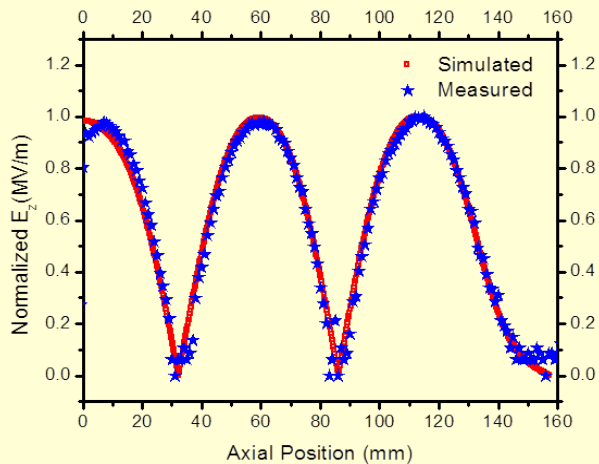


At KEK

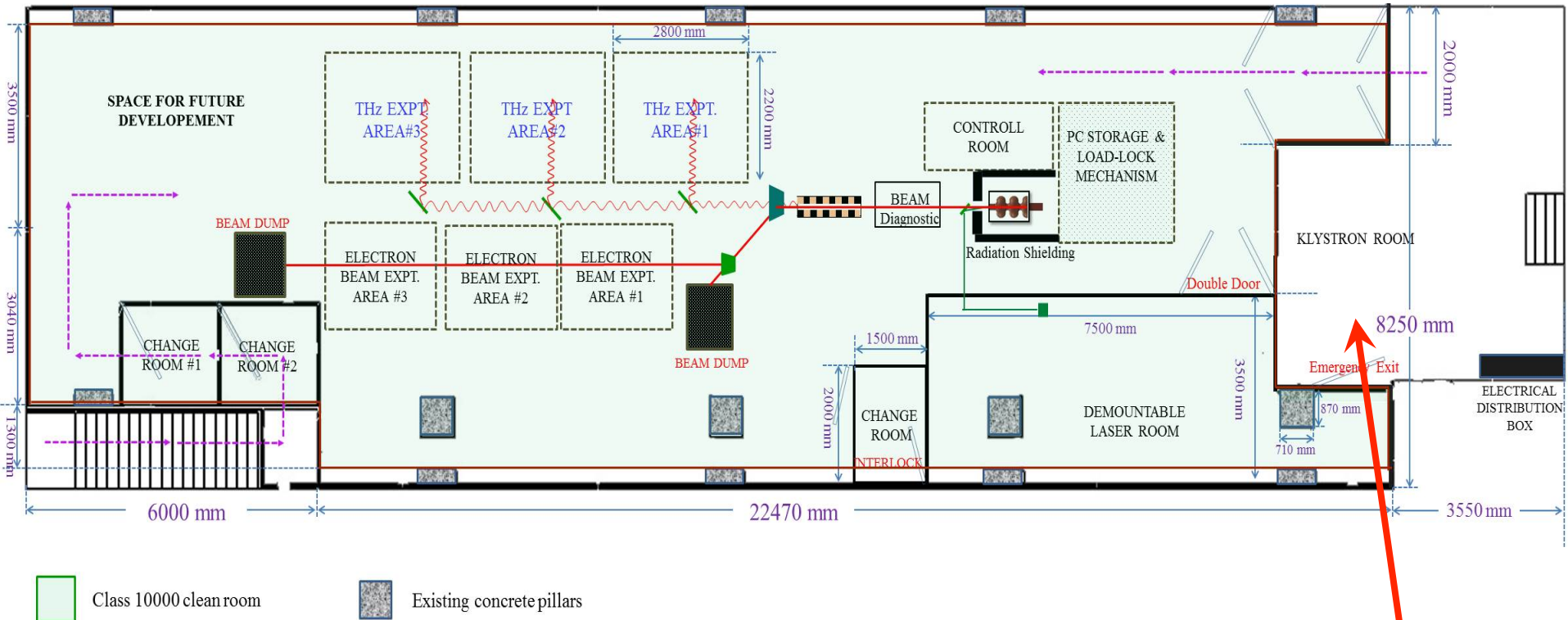


At IUAC

Central frequency = 2859.795 MHz @ 24.8C
 $Q = 0.904$, Metal bead dia ~ 1.89 mm



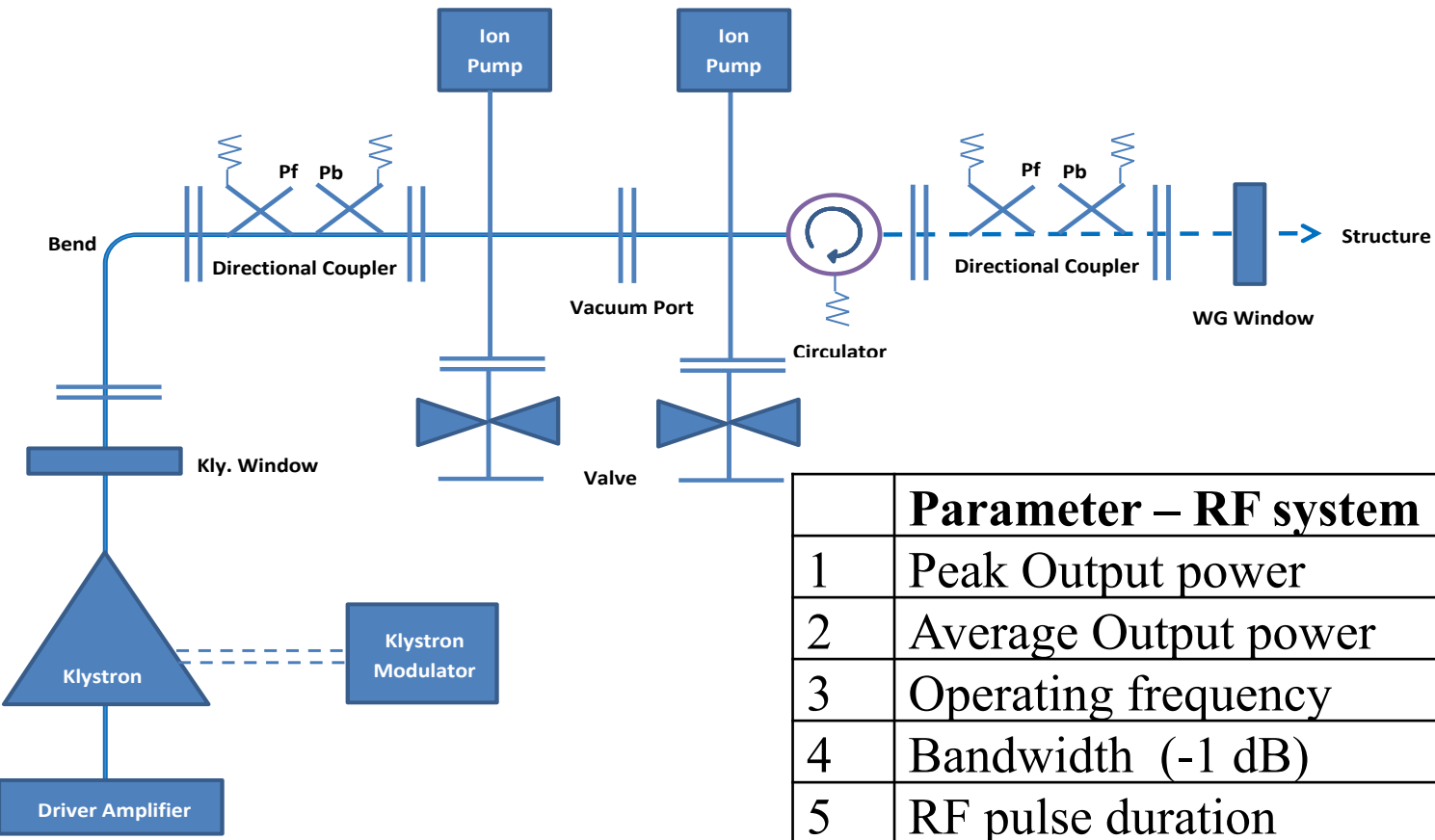
Phase-I of the project: complete layout with expt. stations



Klystron & Modulator



Proposed RF system with circulator



	Parameter – RF system	Value
1	Peak Output power	≥ 25 MW
2	Average Output power	≥ 5 kW
3	Operating frequency	2860 MHz
4	Bandwidth (-1 dB)	± 1 MHz
5	RF pulse duration	0.2 μ s to 4 μ s
6	Pulse repetition rate	1-50 Hz
7	Pulse top flatness	$\pm 0.3\%$
8	Rate of rise and fall of modulator output voltage	200-250 kV/ μ s
9	Long term stability	$\pm 0.05\%$

Order is being placed: Toshiba & Scandinova

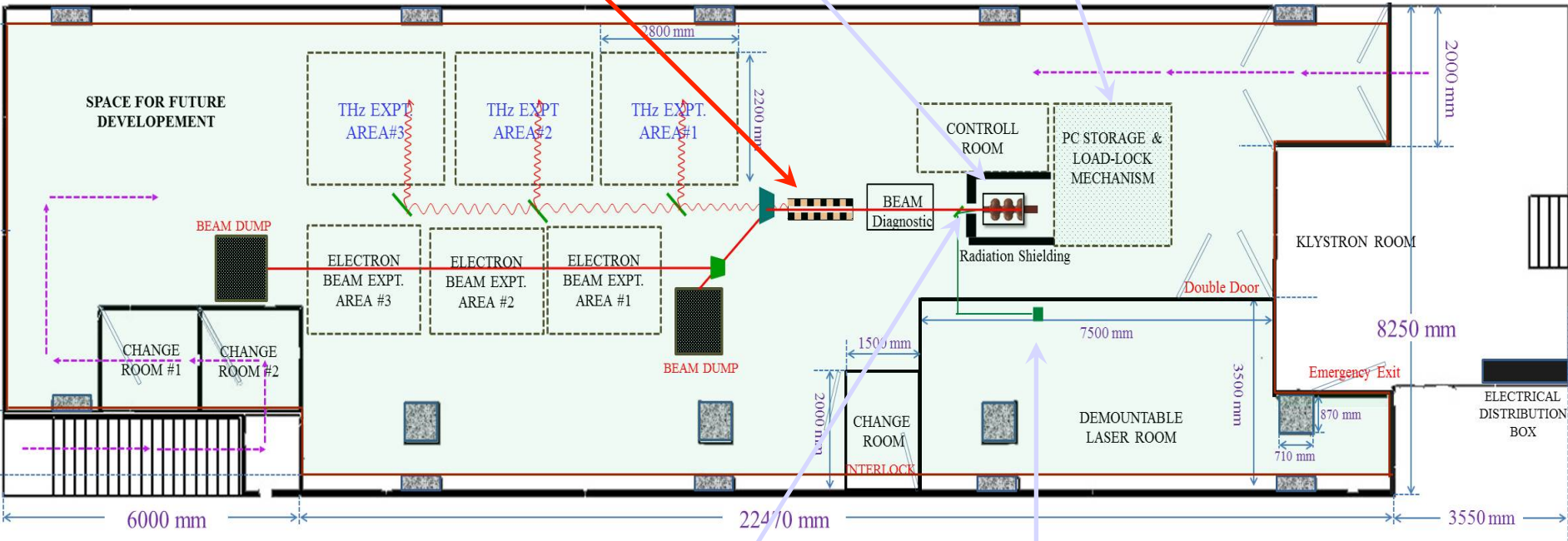


Phase-I of the project: complete layout with expt. stations

Undulator

Cavity

Photocathode Deposition Mechanism

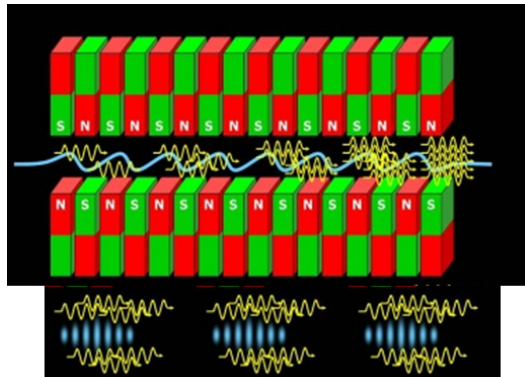


Solenoid

Laser Device



Tentative undulator parameters for THz



λ_R (mm)	Freq. to be Produced (THz)	Electron Energy (MeV)	λ_U (mm)	K – value	B_u (T)	Required gap (mm)
2	0.15	4	40	2.264	0.61	16
0.1	3	8	40	0.475	0.13	36

$$K = e \times B_u \times \lambda_U / 2\pi m c$$

Structure: Planer with PM

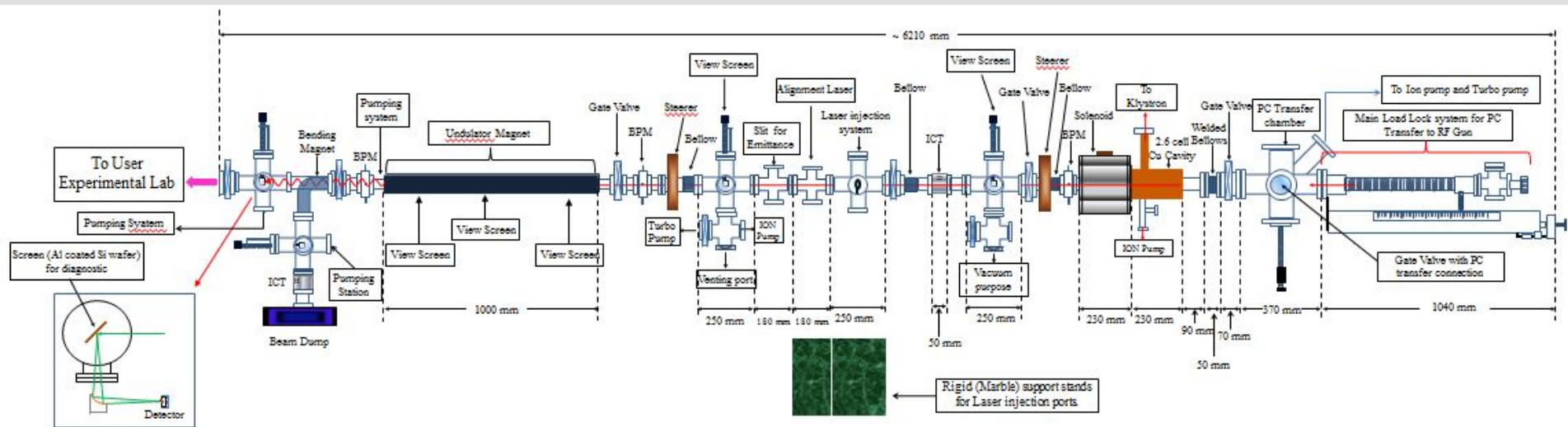
$$\lambda_R = \lambda_U / 2\gamma^2 [1 + K^2/2]$$

$$\gamma = E/E_0$$

$$B_u = 3.694 \exp[-5.068 g/\lambda_U + 1.52 (g/\lambda_U)^2]$$

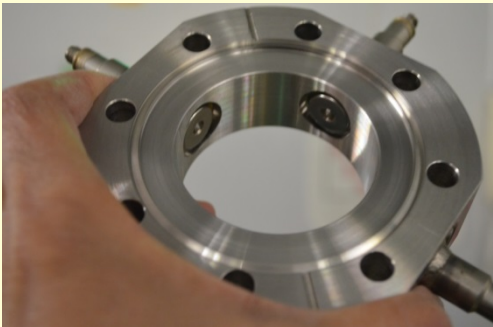
For hybrid undulator made from NdFeB magnet with $0.1 < g/\lambda_U < 1$.

Layout of the beam line of Phase-I

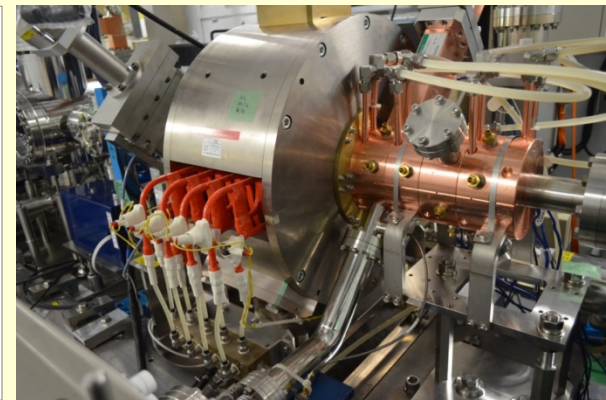
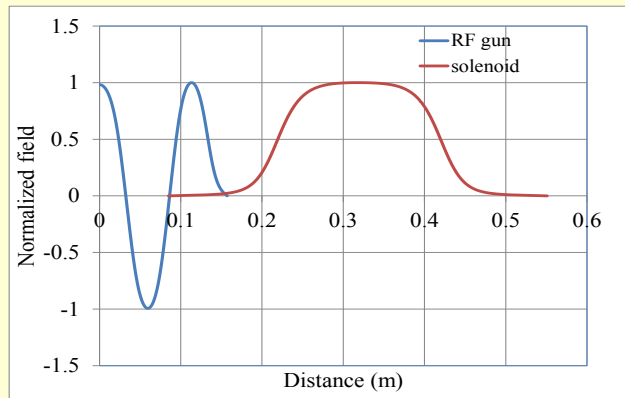


Beam transport/diagnostic devices

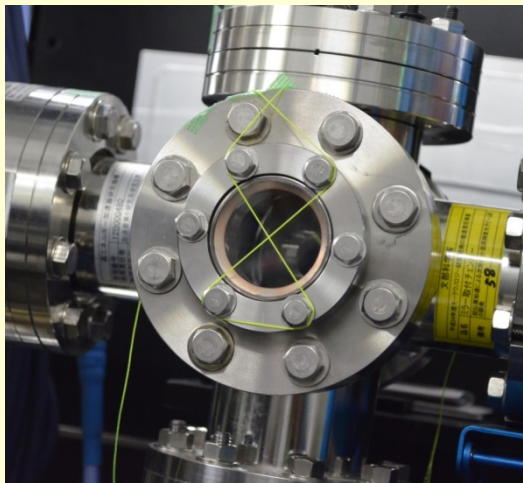
Beam Position Monitor



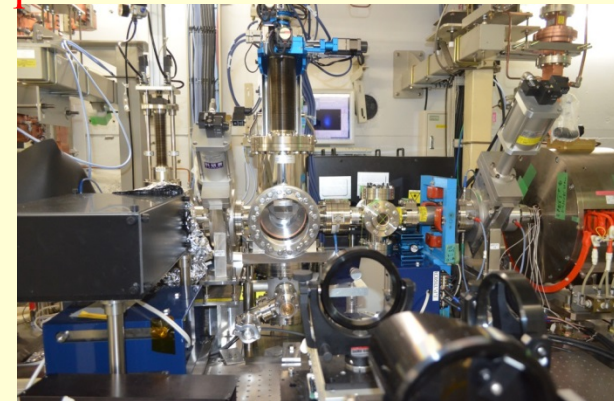
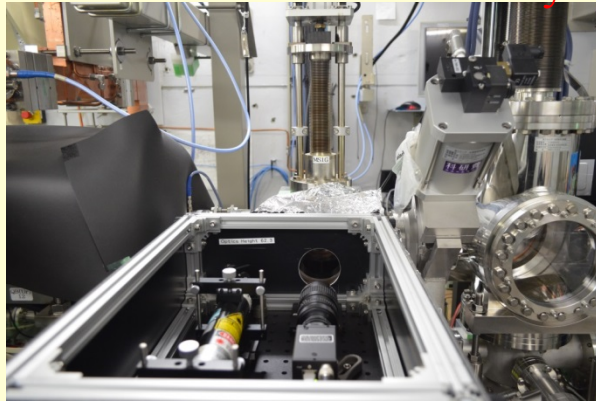
Solenoid magnet to focus the beam



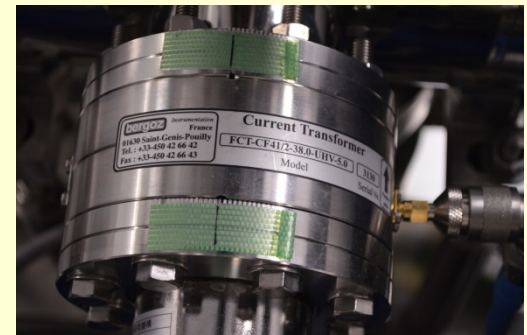
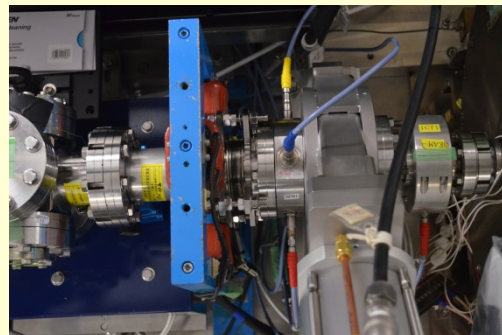
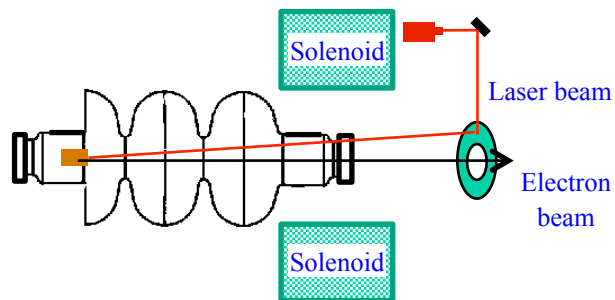
Laser reflection mirror and beam passage



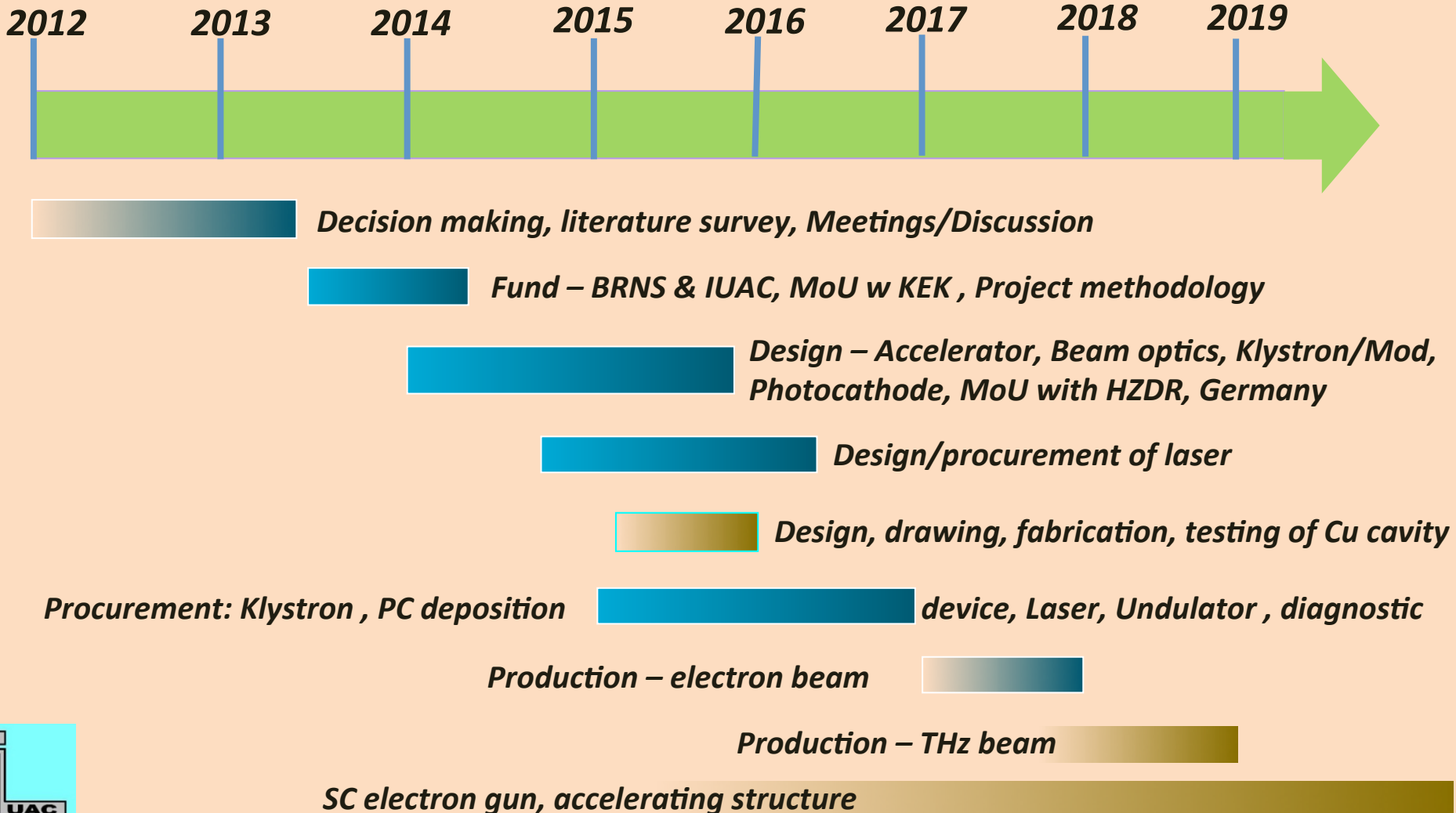
Slit and Faraday cup with Camera



Quadrupole magnet and ICT



Time chart – for Phase I of DLS



Conclusion

- Status of the major components:
 - Copper cavity – Fabricated and tested (LLRF) at KEK, under evacuation at IUAC
 - Klystron/Modulator –order will be placed next month
 - Cu photocathode has been prepared. Design of dep. chamber for Cs₂Te is being done
 - Beam optics simulation is done with ASTRA. Being validated by other GPT.
 - Laser system – Design finalized, development with KEK, Waseda soon
 - Beam line components:
 - Solenoid design is frozen, budgetary estimate is obtained, procurement soon
 - Design of other magnets is being started. Undulator – design stage
 - BPM, FC, other beam diagnostic elements are being procured
- Clean room and other utilities are being prepared. Will be ready by Oct. 2016
- 2016 – required for infrastructure development, equipment procurement, testing & installation
- 2017 – dedicated for generation for e-beam
- 2018 – dedicated for THz generation

Core member of FEL team

INDIAN INSTITUTIONS

1. Dr. D. Kanjilal, IUAC
2. Dr. R.K. Bhandari, IUAC
3. Dr. Gopal Joshi, BARC
4. Dr. S. Ghosh, IUAC
5. Dr. V. Naik, VECC
6. Dr. Manjiri Pande, BARC
7. Dr. A. Deshpande, SAMEER
8. Mr. B.K.Sahu, IUAC
9. Dr. D.Kabriraj, IUAC
10. Mr. P.Patra, IUAC
11. Mr. SRV Abhilash, IUAC
12. Mr. J.Karmakar, IUAC
13. Mr. B.Karmakar, IUAC
14. Dr. N.Kumar
15. Mr. V.Joshi
16. Mr. G.K.Chaudhary, IUAC

JAPANESE INSTITUTIONS

1. Prof. J.Urakawa, KEK
2. Prof. N.Terunuma, KEK
3. Prof. S. Fukuda, KEK
4. Dr. M.Fukuda, KEK
5. Dr. A.Aryshev, KEK
6. Mr. T.Takatomi, KEK
7. Prof. Hirayama, KEK
8. Dr. K.Sakaue, Waseda Univ.
9. Prof. J.Yang, Osaka Univ.
10. Mr. I.Nozawa, Osaka Univ.

OTHER INSTITUTIONS

1. Dr. P. Michel, HZDR,
Germany
2. Dr. T.Rao, BNL, USA

Thanks for your patience



AGTaX Workshop - 30 Sept. 2017



Expected outcome – Phase-I of DLS

- **Electron beam (pulsed)**

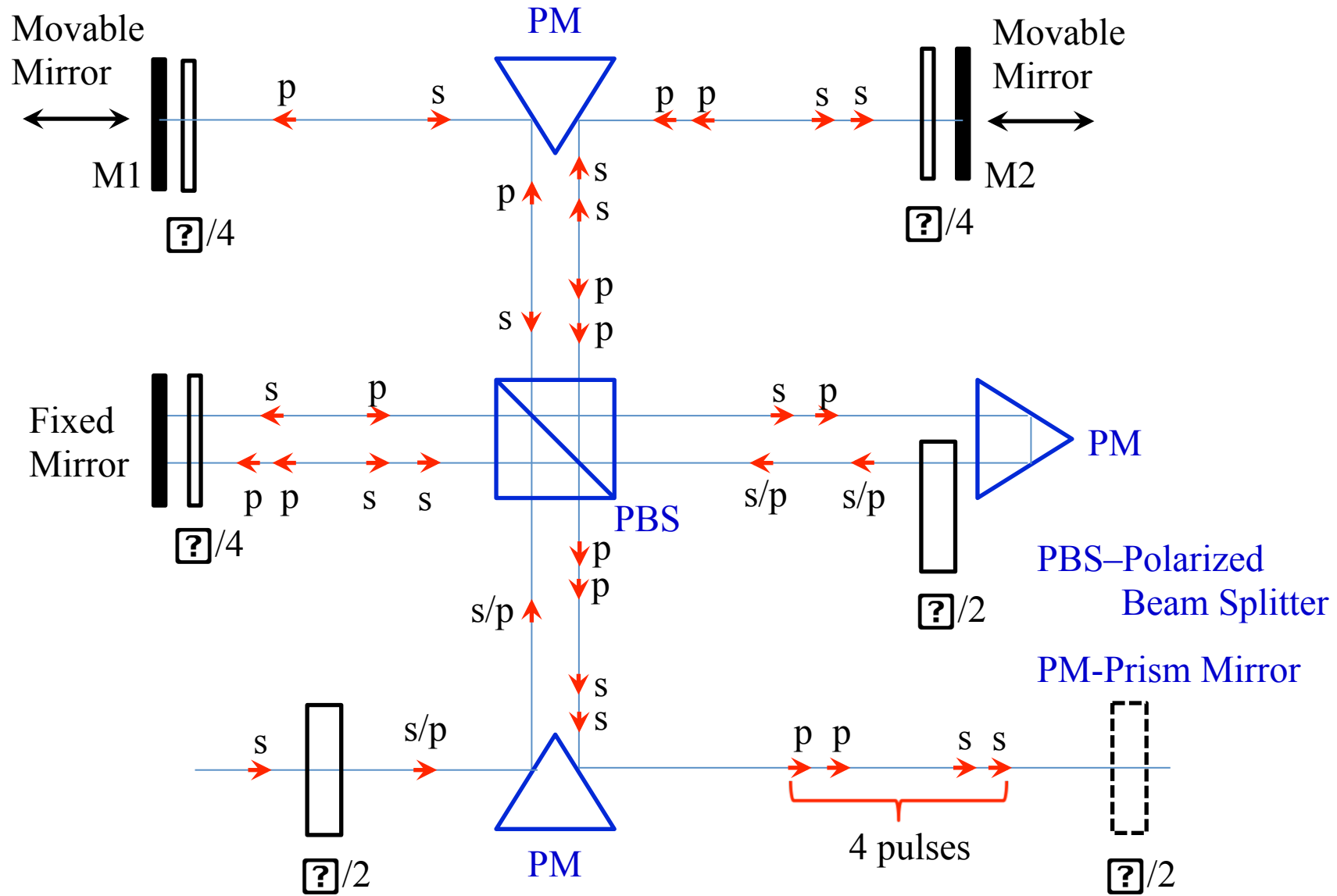
- Energy ~ 8 MeV (max), Emittance ~ 1 pi mm mrad
- Peak current \sim tens to hundreds of Amps, Average current \sim nA
- Time width \sim hundred of fs to a few ps,
- microbunch train of 16 (max) @ 10 Hz

- **THz radiation (pulsed)**

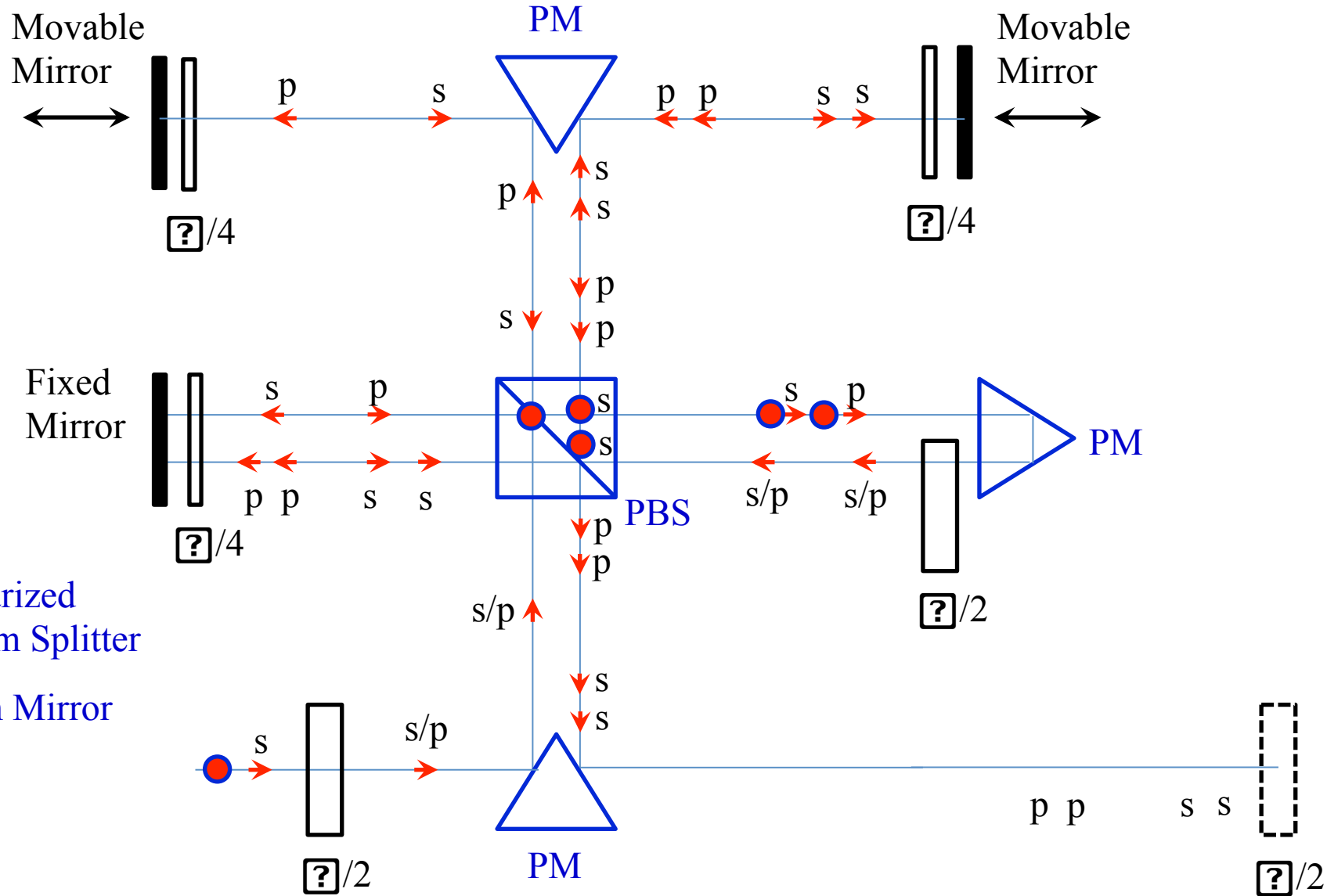
- Frequency range (tunable) ~ 0.15 to 3 THz
- No. of photons per microbunch $\sim 10^{26}$ (FWHM ~ 500 fs, separation ~ 700 fs, $f\sim 1.4$ THZ)



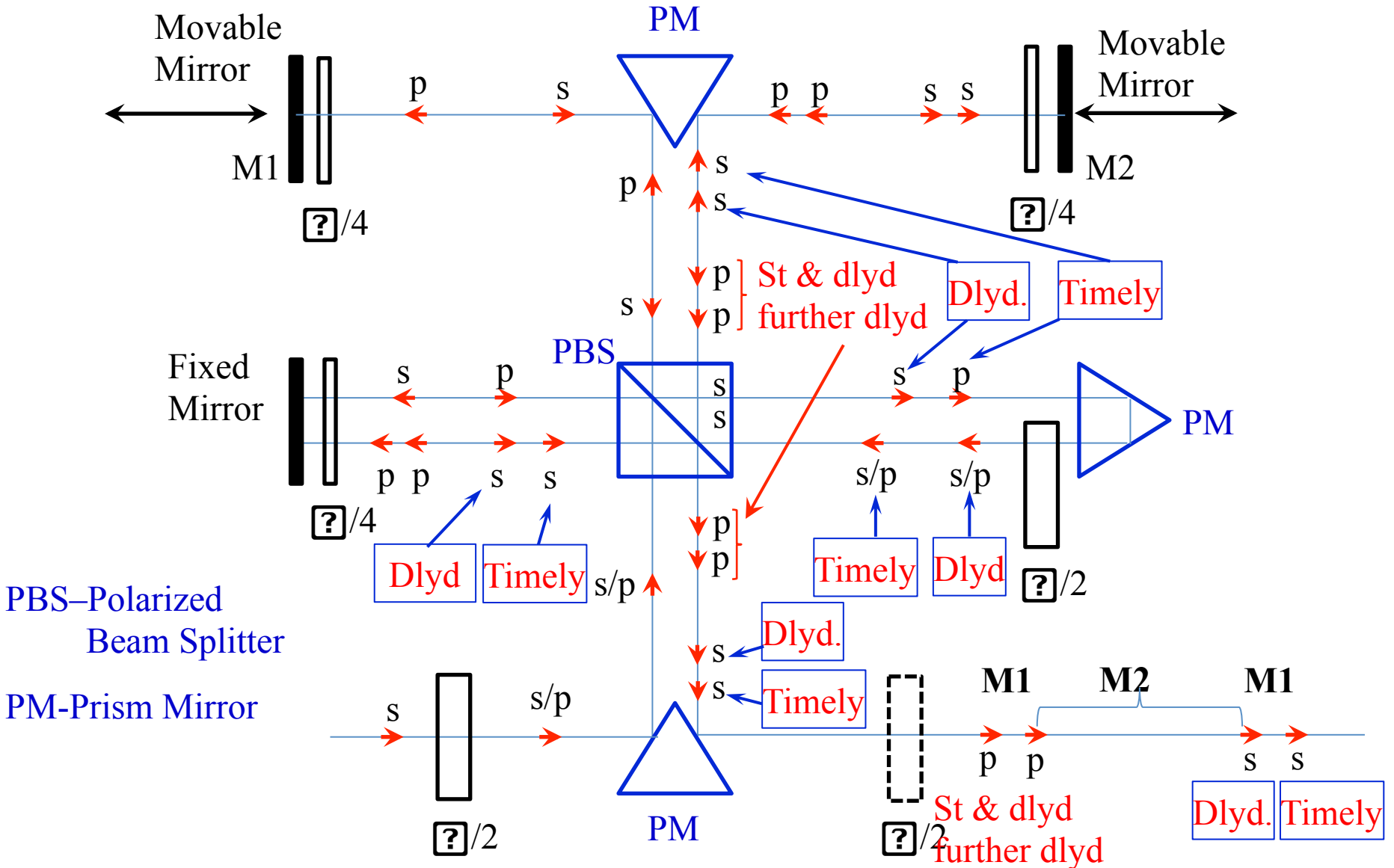
A single laser pulse is split in to four laser pulses with variable separation



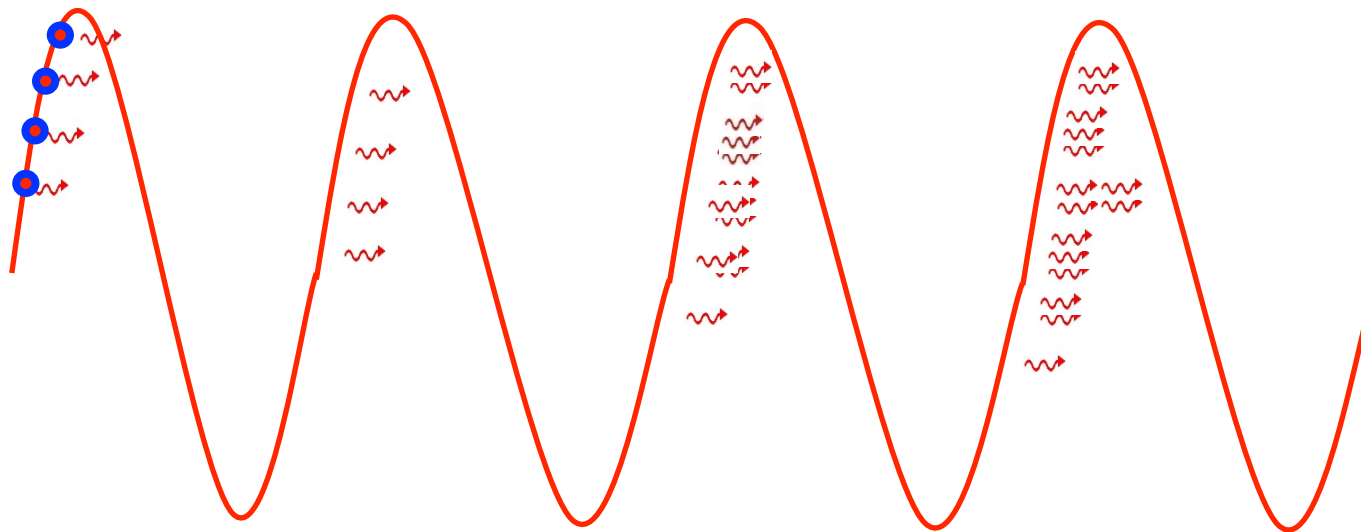
A single laser pulse is split in to four laser pulses with variable separation



A single laser pulse is split in to four laser pulses with variable separation



Where Photon meets Electron



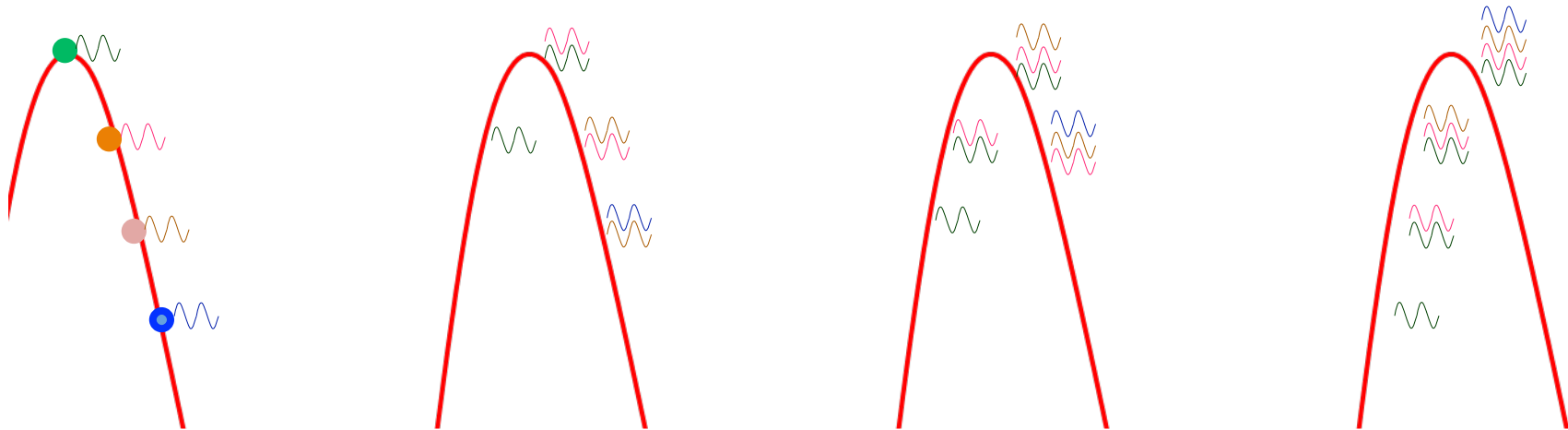
$$v_z = c \beta [1 - (1 + K^2/2)]$$

$$\beta U/c = \beta U - \beta A$$

freq (THz)	Energy (MeV)	K_undulator	Longitudinal Velocity of electron (v _z) m/sec	Undulator wavelength (m)
0.15	4	2.982	2.8667E+08	0.045
0.3	5	2.552	2.9333E+08	0.045
0.6	6	2.032	2.9667E+08	0.045
1	7	1.733	2.9800E+08	0.045
2	7	0.709	2.9900E+08	0.045
3	8	0.423	2.9933E+08	0.045

Where Photon meets Electron

$$\gamma U/c = \gamma U - \gamma R/v_z \quad v_z = c \left[1 - (1 + K^2/2) / 2\gamma^2 \right]$$

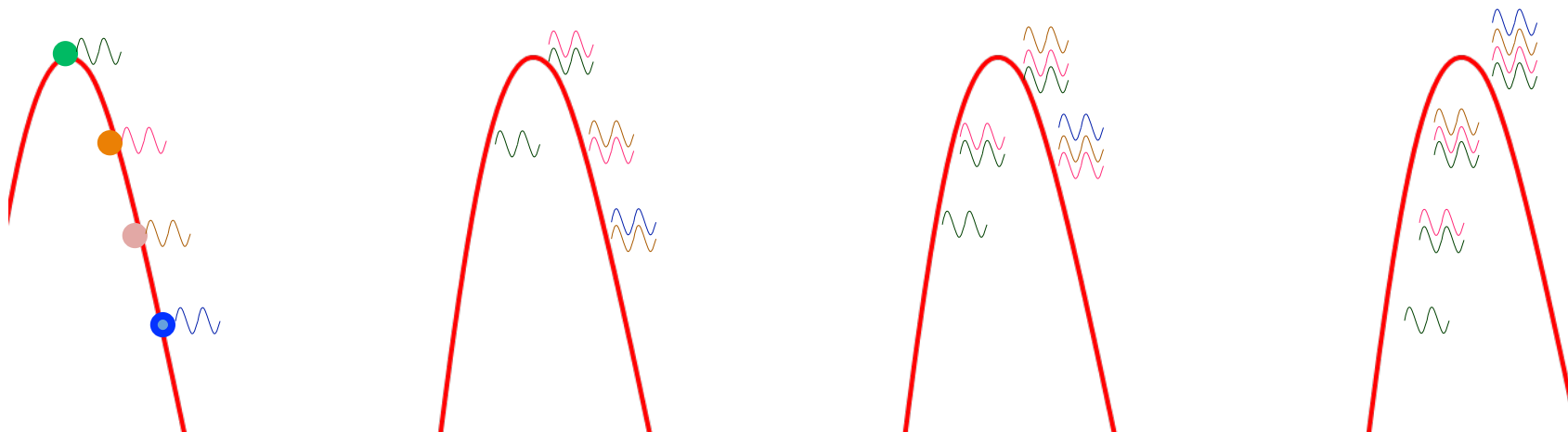


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Where Photon meets Electron

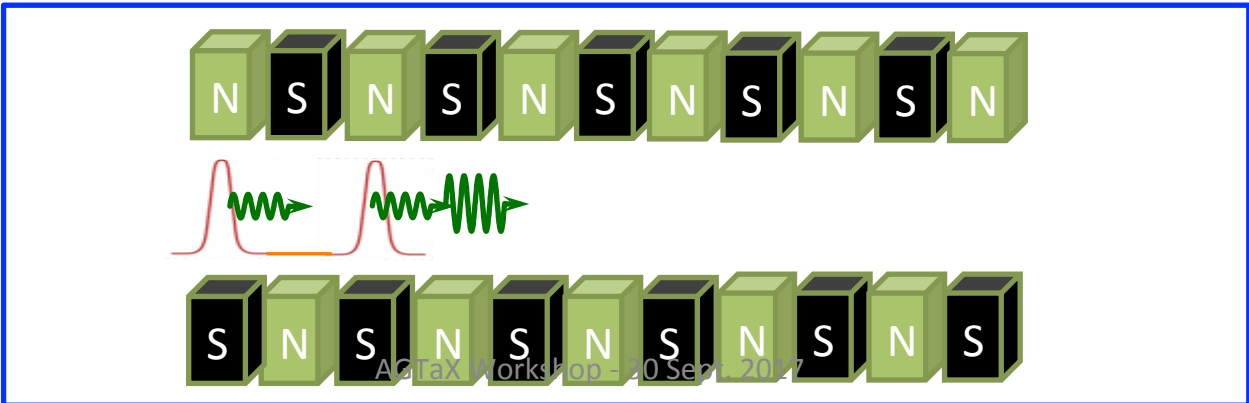
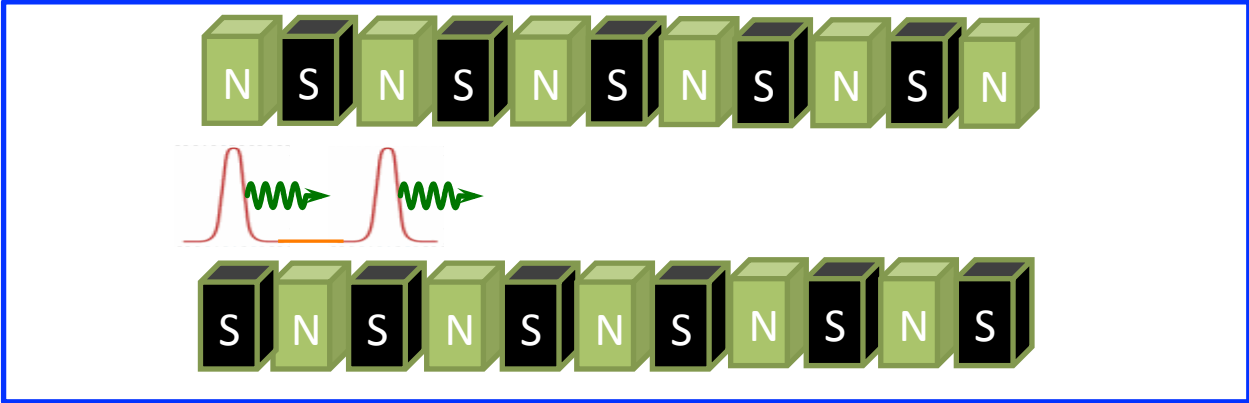
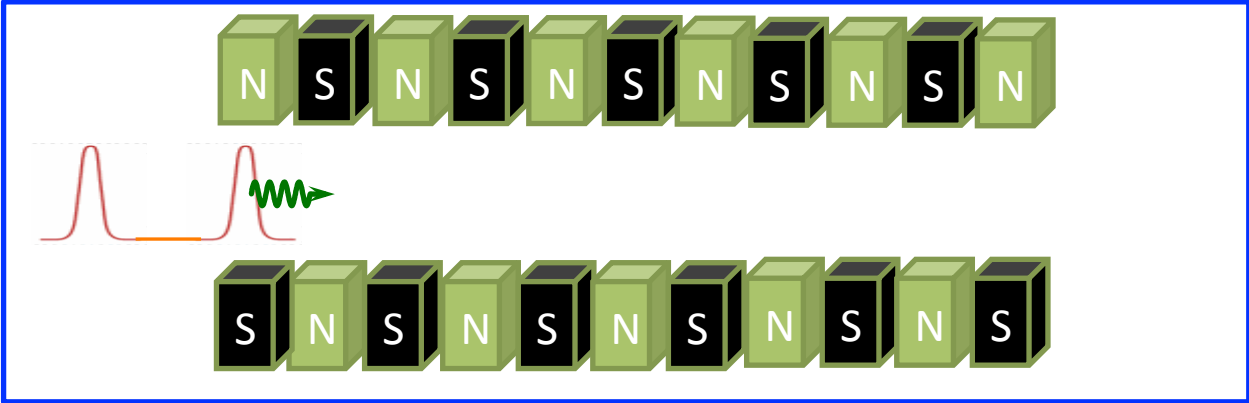
$$I \propto (N_1 + N_2 + N_3 + N_4)^2 \text{ or } I \propto N^2$$

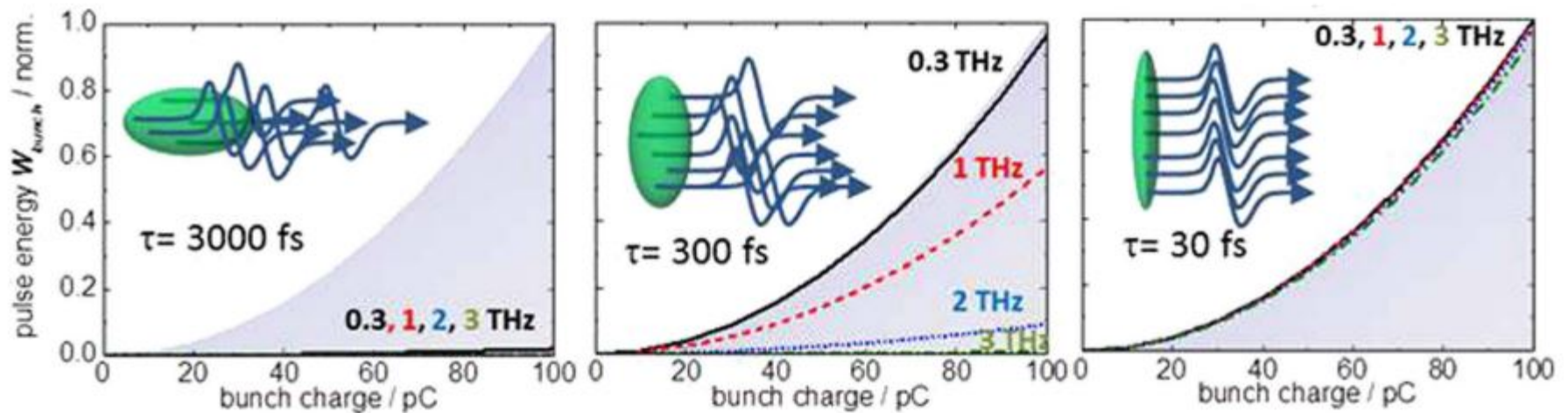
Four bunches of photon with a separation of one radiation wavelength will be emitted



freq (THz)	Energy (MeV)	K_undulator	Longitudinal Velocity of electron (v_z) m/sec	Undulator wavelength (m)
0.15	4	2.982	2.8667E+08	0.045
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Conventional FEL



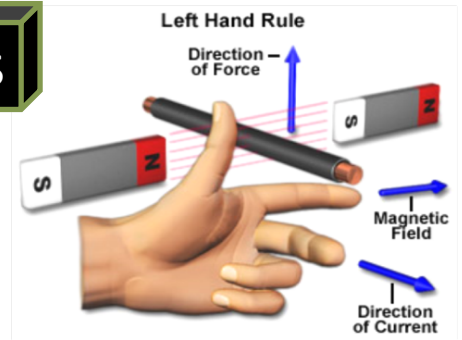
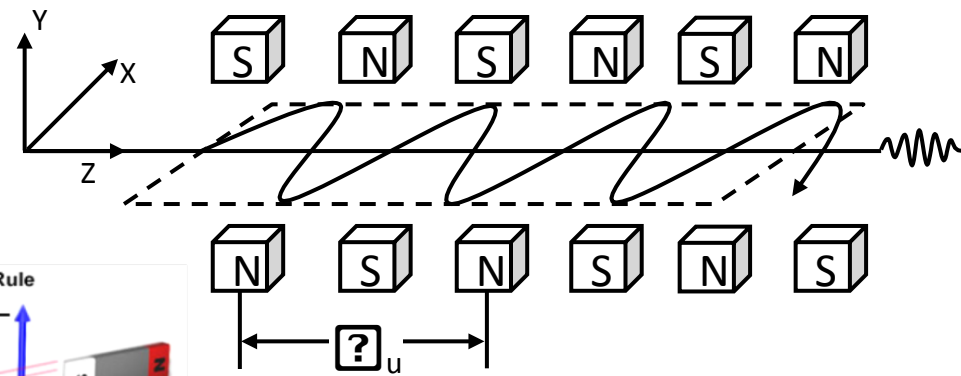
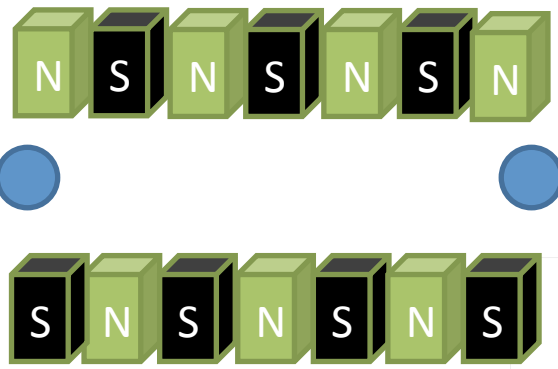


Superradiant radiation – Possible to produce frequencies when it is $\ll 1/\tau$ [$1/30$ fs = 33.3 THz

If the time width of the electron beam bunch is ~ 100 fs, then $1/\tau = 10$ THz

Figure 2. Fundamental principle of superradiance. Superradiant emission from electron bunches becomes significant for frequencies sufficiently lower than the inverse of the bunch duration τ . Following equation (1) the emission scales quadratically with the charge at low enough frequencies but diminishes at higher frequencies when a smaller fraction of the charge fits within the wavelength. This behavior can be described by the dimensionless form factor f . (a) Form factors plotted for an assumed Gaussian bunch form with duration (FWHM) of 3000 fs, 300 fs and 30 fs (grey-shaded). (b) Corresponding dependence of the pulse energies at THz frequencies of 0.3 THz (black solid), 1 THz (red-dashed), 2 THz (blue-dotted) and 3 THz (green-dash-dot) on the bunch charge. For simplicity a “white” radiator with a frequency independent emission characteristic is assumed. The upper edge of the blue-shaded area corresponds to the case of a form factor equal to 1.

Conventional FEL



Electron energy = 5 MeV

$\lambda_U = 30 \text{ mm}$

$g = 10$

$\lambda_U^* = 3 \text{ mm}$

$\lambda_R = 3/20 = 150 \text{ nm}$
 $= 2 \text{ THz}$

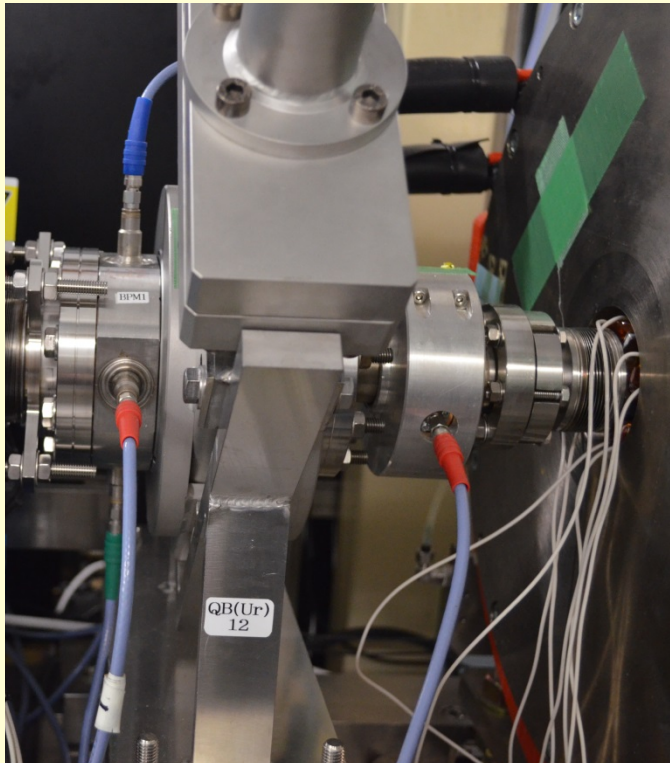
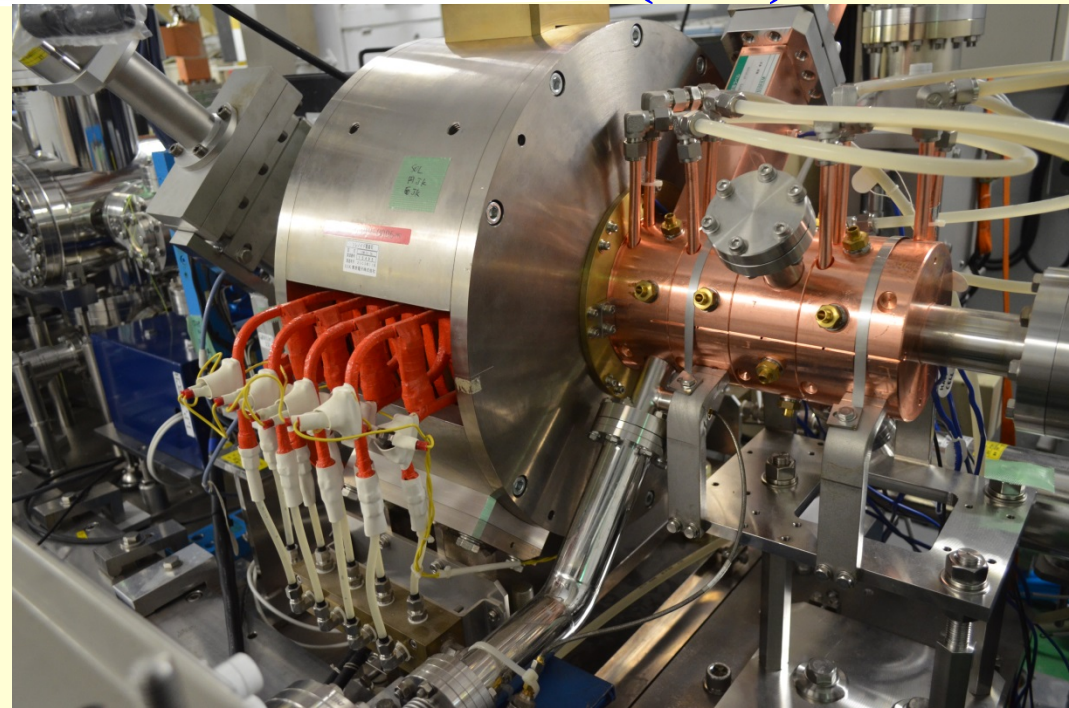
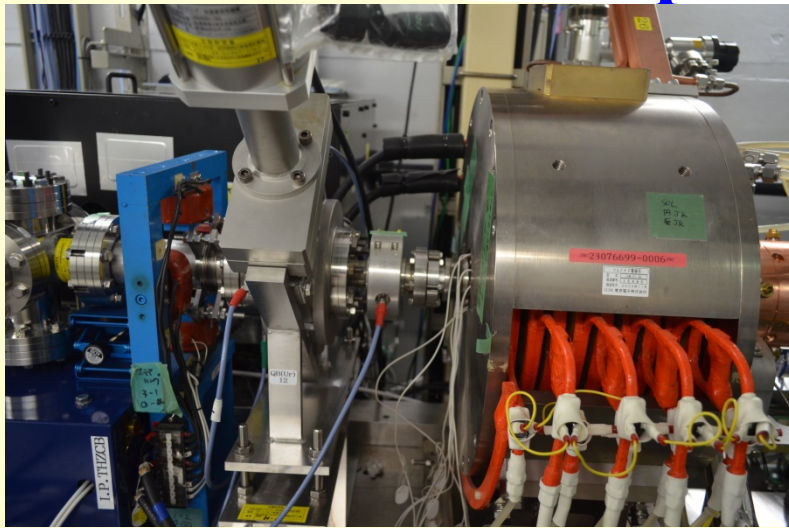
Major points:

- Relativistic electron
- Approaching Undulator magnet, λ_U
- λ_U - length contracted to $\lambda_U^* = \lambda_U/\gamma$, $\gamma = E/E_0$
- λ_U^* = Emitted wavelength from the electron
- Wavelength (lab fr.) = $\lambda_R = \lambda_U^*/2\gamma = \lambda_U/2\gamma^2$, relativistic Doppler
- Including the parameter of Undulator, wavelength measured will be

$$\lambda_R = \frac{\lambda_U}{2\gamma^2} [1 + K^2] \text{ where } K = \frac{eB_U \lambda_U}{2\pi mc}$$

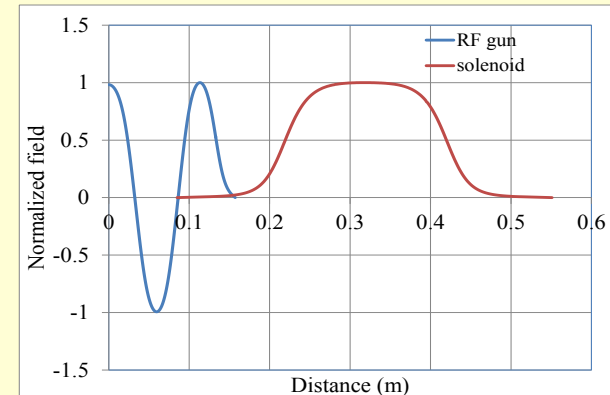
Electrons radiate spontaneously, now coherence is to be established

Beam transport device – Solenoid (NC)



Specification for the solenoid magnet :

- Beam optics calculation demands ~ 0.27 T (max)
- Measured fields should be ~ 0.32 T (Max)
- Through bore dia ~ 75 mm
- Return Yoke is necessary
- IDX-Japan supplied the solenoid to KEK

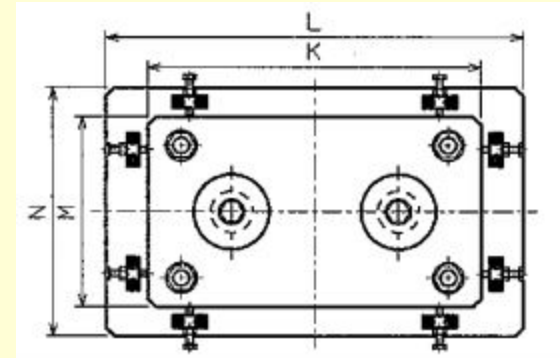
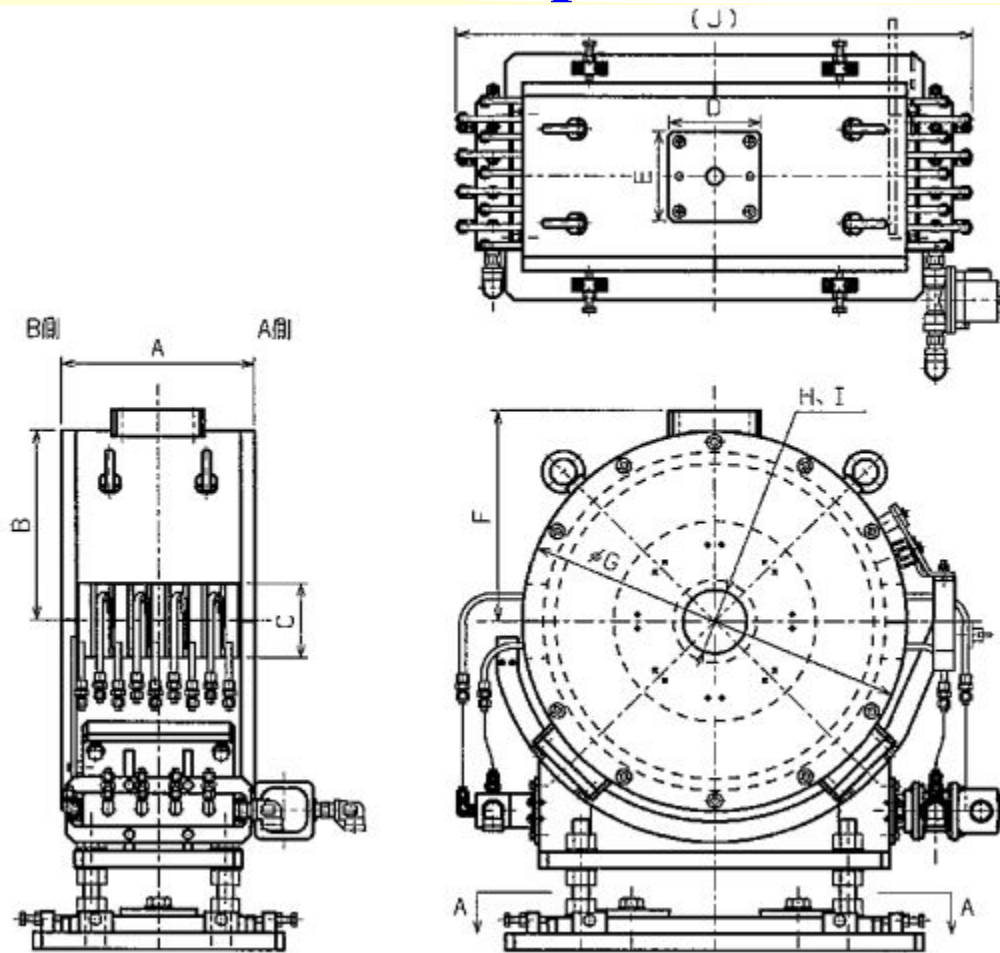


Specification list of the Solenoid

Parameters	Values
Maximum magnetic Field at the Centre of the solenoid	0.35 T
Physical Length including mirror plate	≤ 240 mm
Overall Diameter	≤ 480 mm
Effective Length	~ 200 mm
Bore Diameter	76 mm, It should fit over 2.75" flange
Alignment mechanism/marks	Yes
Alignment Tolerances, both X and Y	≤ 0.1 mm
Axial Field at a distance of 200mm from the centre of the solenoid magnet	< 30 Gauss
Inlet Water Pressure available at customer's site	~ 5 bar
Field Homogeneity	$\sim 5 \times 10^{-3}$ within ± 20 mm around the middle of the solenoid along the transverse and longitudinal direction
Stainless steel (Non-magnetic) support stand to be provided with ± 20 mm in X,Y and Z plane adjustments. The axis of the solenoid magnet (the height of the beam line) is 1.1 m.	
On the entrance side of the mirror plate, 16 tapped blind holes should be provided about the centre of the solenoid Pitch circle diameter (PCD) = 188 mm, Thread size = M4 , Depth of the blind tapped hole ≤ 8 mm	
Alignment marks on both sides (entrance and exit) of solenoid magnet to be provided for both X and Y axes	
Offset between Physical and magnetic axis of solenoid should be ≤ 0.1 mm.	
Matching power supply for solenoid magnet to be provided with remote polarity reversal option.	
All the current leads and all the water connections should terminate on the same side of the solenoid magnet	
Tolerance for Effective length: $\pm 2\%$ of the specified value in above table.	
Yoke material: Solid XC 06 or equivalent. (The composition of the material should be mentioned and the test certificate should be provided. Material should be tested for porosity).	

Beam transport device – Solenoid (NC)

Mechanical design & tolerances of LUCX's solenoid



Measurin g	Referenc e value	Tolerance	Measured Value	Measurin g	Referenc e value	Tolerance	Measured Value	
A	230	±0.3	230.0	H	76	±0.2	76.0	A side
B	230	±0.3	230.0	I	76	±0.2	76.1	B side
C	90	±0.5	90.0	J	(620)		630	
D	110	±0.3	110.0	K	400	±0.6	400.0	
E	110	±0.3	110.0	L	500	±0.6	500.1	
F	255	±0.1	254.93	M	230	±0.3	229.8	
G	460	±0.5	460.1	N	300	±0.3	300.0	[Unit : mm]

Beam transport device – Solenoid (NC)

Decision to be taken on:

Laser device:

- KEK's offer – buy the components & assemble the complete device by laser experts (\$200K)
 - To be developed in collaboration with KEK, addendum on MoU is initiated
 - Less expensive, to be tested with KEK's RF gun to produce e-beam
 - Much better hands on training (~ 1.5 months) during the assembly of different parts
- About 50% (100K) - unspent - collaborative project with KEK to fabricate Cu cavity
- If committee agrees - amount may be utilized for Laser, remaining \$100K to be funded - IUAC

Photocathode Deposition Device:

- Decision in last meetings – Global tendering after finalization of all the design parameters
- Design is frozen now, like to contact a few companies informally for their feedback e.g.
 - Kurt J. Lesker Inc., USA
 - VACOM Vakuum Komponenten & Messtechnik GmbH, Germany
 - Mewasa AG, Switzerland
 - Toyama, Japan – already contacted for their feedback about the feasibility of the PC device

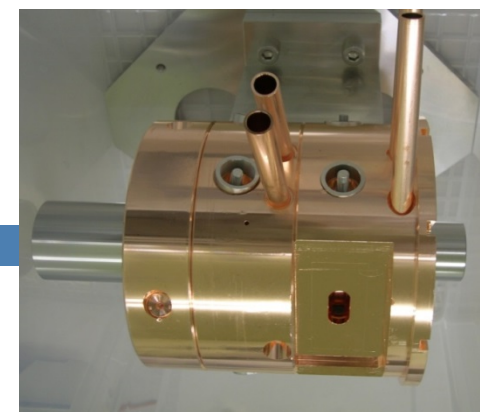
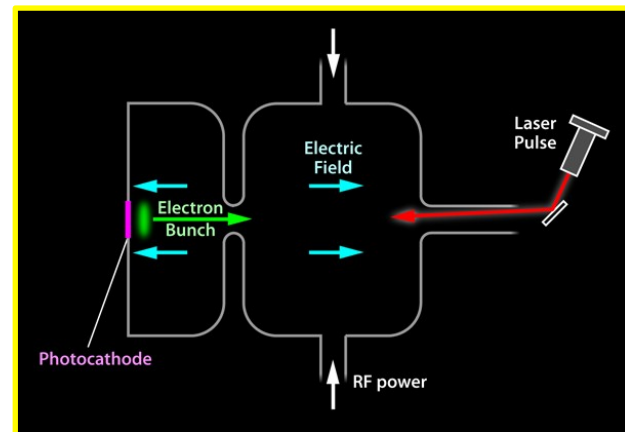
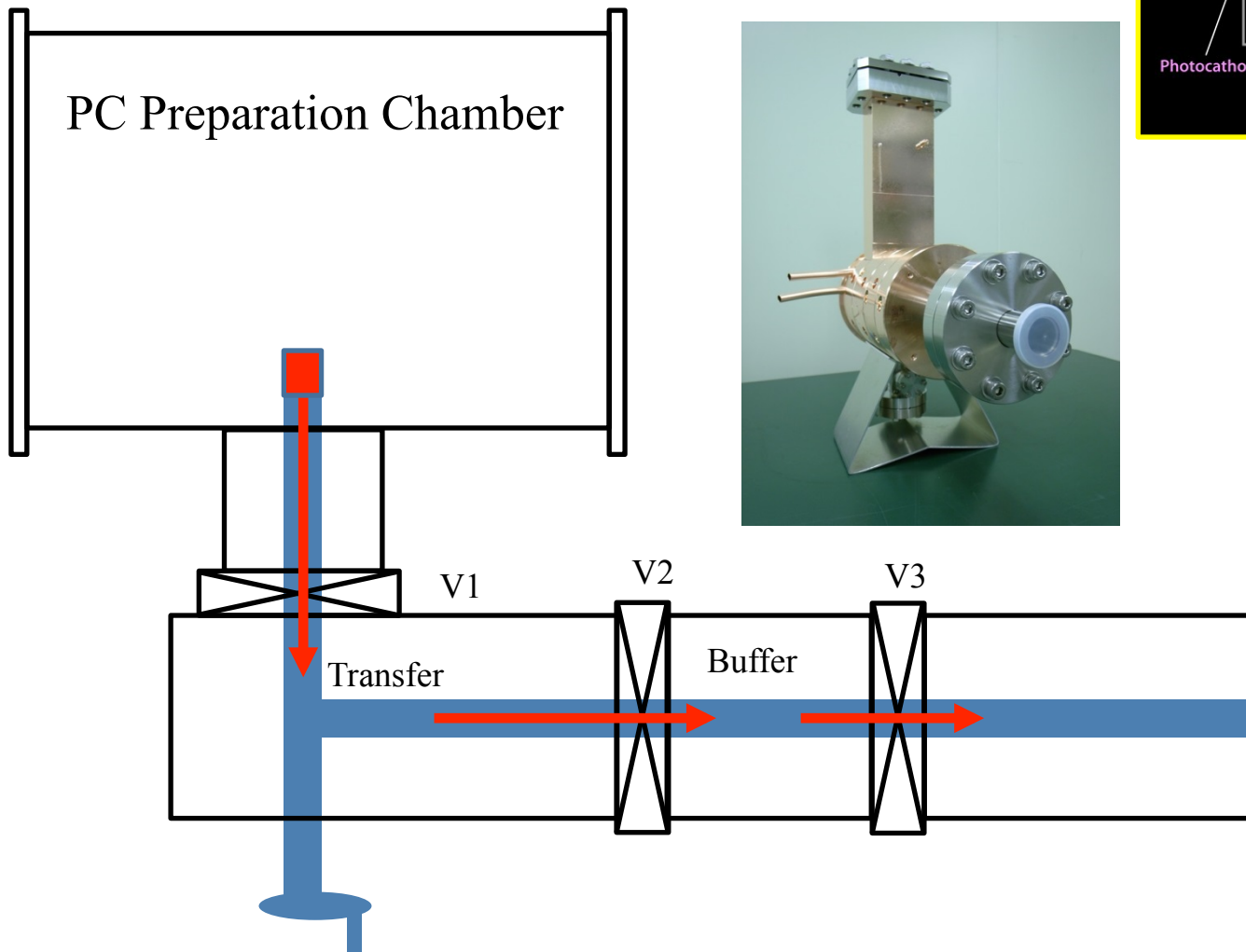
EMD waiver

Solenoid Magnet:

- Decision in last meeting – limited tendering after finalization its parameters
- Tender document is ready. Companies chosen to be contacted for limited tendering –
 1. Danfysik, Denmark,
 2. SigmaPhi, France,
 3. IDX, Japan

EMD waiver

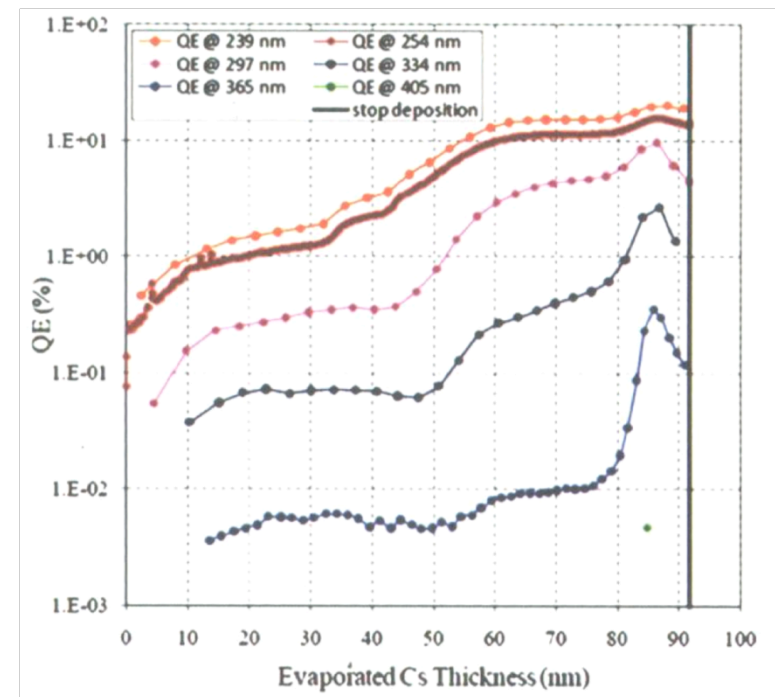
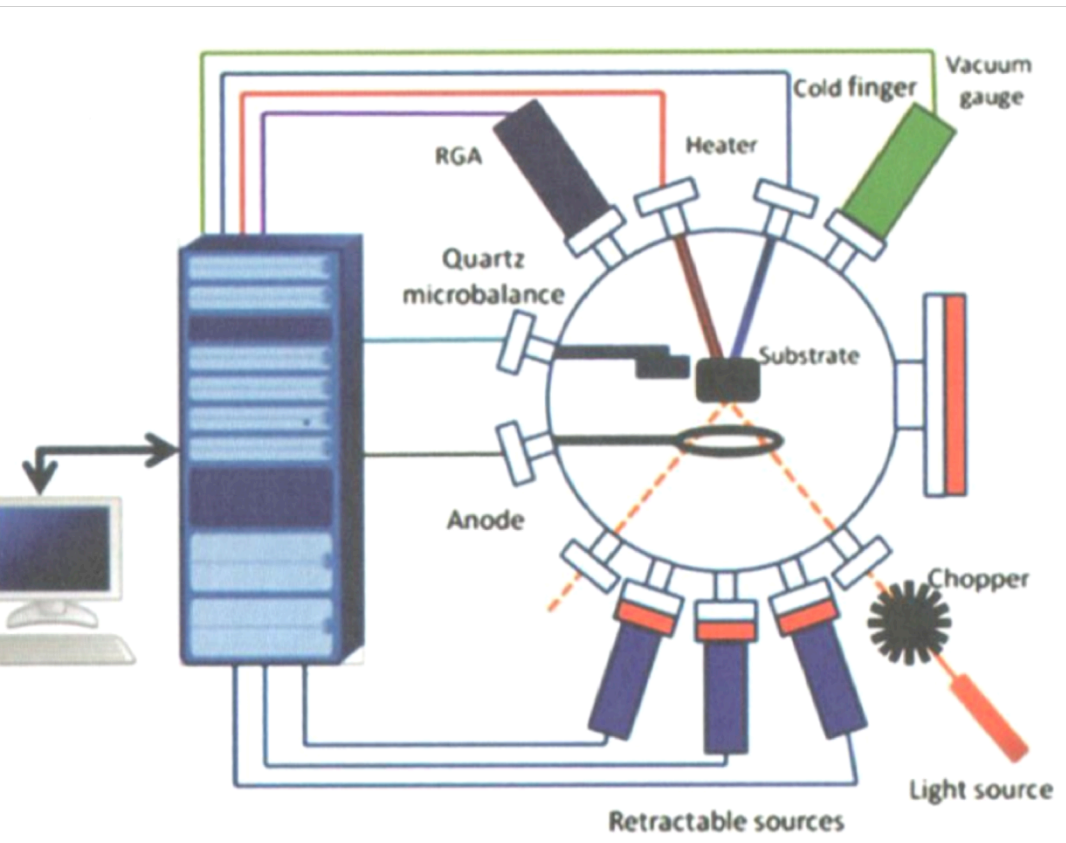
Photocathode insertion in to the cavity



Details of Photocathode

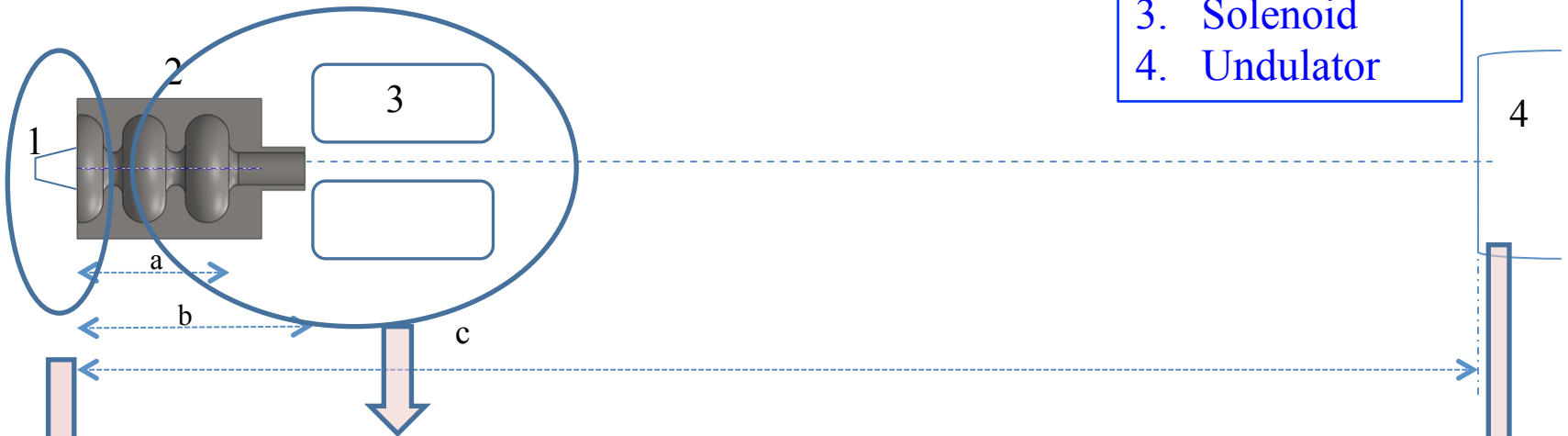
Main Steps to produce Cs_2Te photocathode

- Substrate – Mo – to be held at 120 C, while ~ 10 nm Te is deposited @ 1nm/m
- Film illuminated by UV light, Cs evaporated-same rate, Photocurrent monitored
- Max QE, source, substrate heater put off to be cooled naturally / rapidly cold finger
- Maximum QE is recorded around ~ 100 nm, Vacuum $\sim 10^{-11}$ mbar



Design of Solenoid - Beam optics simulation by ASTRA

1. Photocathode
2. Cavity
3. Solenoid
4. Undulator



- Parameters at rf gun and solenoid:**
- Laser injection phase (RF phase what electron sees at the photocathode)
 - Max possible E field of gun
 - Optimize B field of Solenoid

- Parameters at cathode:**
- Laser spot size
 - Bunch emission time
 - Charge/e-bunch
 - Initial transverse emittance

- Results (important parameters):**
- Transverse emittance
 - Spot size
 - Bunch time spread
 - Energy
 - Energy spread

Development of Phase-I of DLS

Physics Design

Choice of Accelerator Components

Elect. & Cont.

- RF cavity – Copper (NC), S-band, 2.6 cell, water cooled, \approx 0.1 C
- Frequency – 2860 MHz unlike 2856, SC PI/cavity : 130/1300 MHz
- **Photocathodes** – **Copper to start – easy, rugged, less sensitive vac**
 - **Cs₂Te – Design frozen, Detail dwg. goes on**
- Laser – Conventional vs Fiber – Most probably Fiber laser - Choice
 - single pulse will be split in to many
- Klystron, Modulator – specification are frozen, tender floating soon
- **Solenoid**, other magnet – **Solenoid design frozen**, place order soon
- Undulator – preliminary design – detail design starts soon

Procurement of Photocathode preparation equipment

Toyama Japan – Supplies various instruments which require UHV and precision m/c technology
 - Supplies many PC deposition mechanism to KEK – LUCX, ATF, Photon factory



Address: 3816-1, Kishi, Yamakita-machi,
 Ashigarakami-gun, Kanagawa 258-0112, JAPAN
 Phone: +81-465-79-1411
 Fax: +81-465-79-1412
 URL: <http://www.toyama-en.com>

15Z00564-BT-01-0
 November 20, 2015

To: Dr. Subhendu Ghosh
 Scientist "G",
 Inter University Accelerator Center,
 Aruna Asaf Ali Marg,
 New Delhi - 110067, India.

Budgetary Quotation for Photocathode Preparation Chamber

We are pleased to submit herein the budgetary quotation of Photocathode Preparation Chamber in response to your inquiry as follows:

No.	Components	Q'ty	Price (JPY)
1	Photocathode Preparation Chamber	1set	¥14,600,000.-
2	Packing and FCA cost	1set	¥400,000.-
Total Offer Price			¥15,000,000.-

Option

OP-1	Vacuum components	1set	¥9,800,000.-
OP-2	Installation work at site	1set	¥1,800,000.-

Yen 15,000,000 = Rs 80,66,432
 Yen 11,600,000 = Rs 62,38,040/



Address: 3816-1, Kishi, Yamakita-machi,
 Ashigarakami-gun, Kanagawa 258-0112, JAPAN
 Phone: +81-465-79-1411
 Fax: +81-465-79-1412
 URL: <http://www.toyama-en.com>

(Attachment sheet)

Detail Scope of Supply

No.	Description	QTY	Remarks
1.	Photocathode Preparation Chamber		
	1) Vacuum chamber	1 set	
	2) Rotary motion feedthrough	1 set	UHV compatible
	3) Stepper Motor and cable	1 set	
	4) Magnet coupling for cathode transfer	8 set	UHV compatible
	5) Cathode (made of Mo)	1 pc	
	6) Cathode transfer fittings	1 set	
	7) Load Lock Adjuster	1 set	
	8) Support stands	1 set	
	9) Engineering	1set	
	10) Test and Documentation	1 set	
2.	Packing and FCA cost		
	1) Safety packing by wooden cases	1set	
	2) Export customs fee in Japan	1set	
OP-1	Vacuum components		
	1) Gate valves (manual operation)	5 sets	ICF152 3sets ICF203 2 sets
	2) Ion Pumps (300L/s) with controllers and HV cables	2 sets	
	3) TMP (300L/s) with controllers and cables	3 sets	
	4) Baking heater and thermocouples	1set	
	5) Baking heater controller	1 sets	
OP-2	Installation work at site		
	1) Travel and accommodation expense	1 set	
	2) Driving fee	1 set	

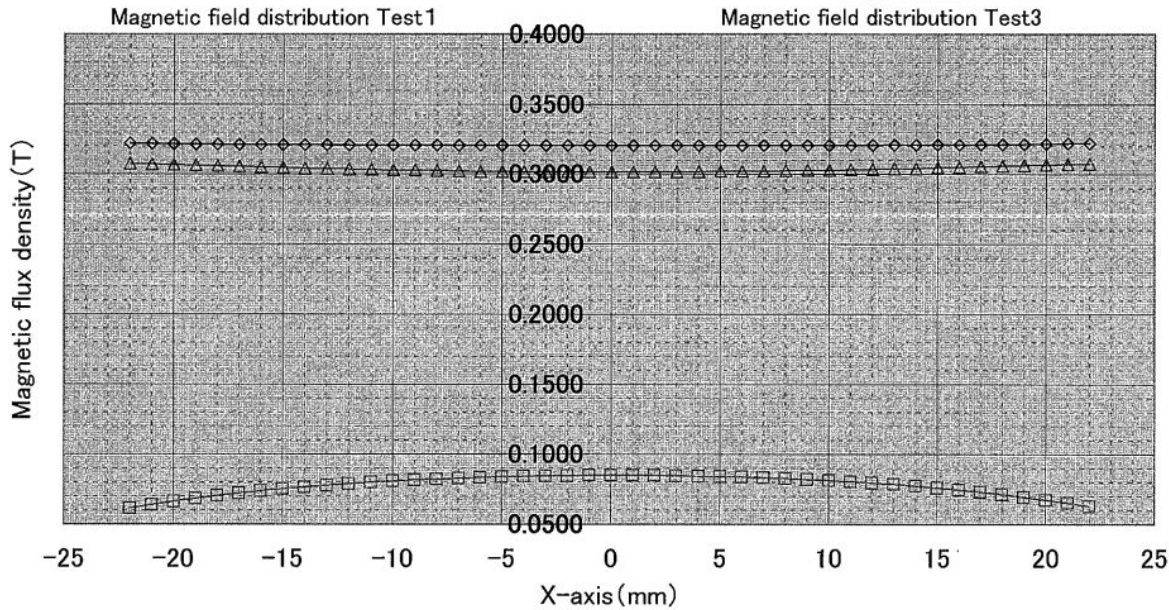
AGTaX Workshop - 30 Sept, 2017

Beam transport device – Solenoid (NC)

9 Magnetic field distribution Test

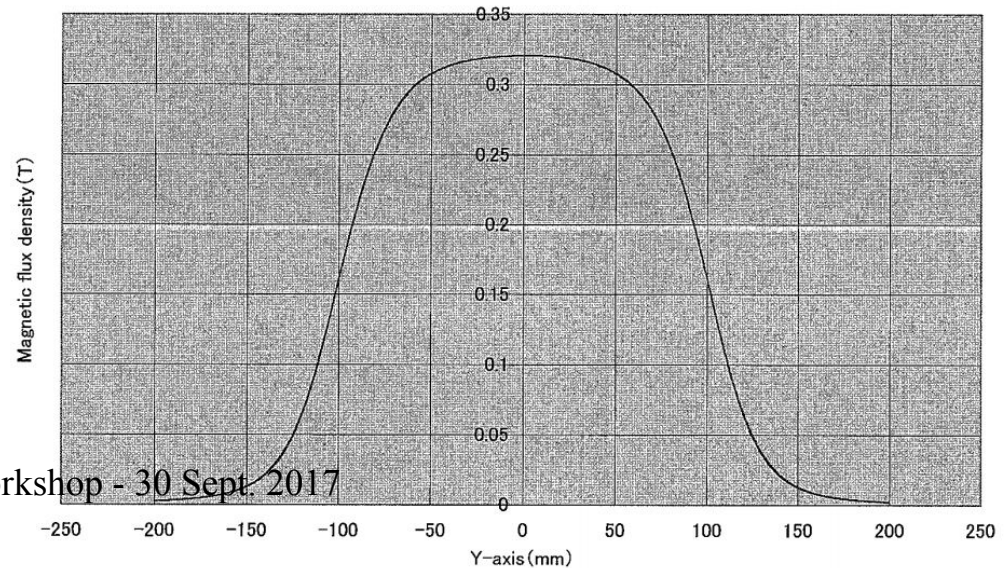
Magnetic field distribution Test2

—◇— 磁場分布測定1 —□— 磁場分布測定2 —△— 磁場分布測定3



Test report of LUCX's solenoid
by IDX Japan

9 Magnetic field distribution test



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Specification offered for the Solenoid

Danfysik

SOLENOID MAGNET SPECIFICATION SHEET

QUOTATION: IND502989
PREPARED FOR: IUAC
DESCRIPTION: Solenoid magnet for FEL
DATE: 5 Feb. 2016

MAIN SPECIFICATION:

Maximum field, B:	0.35	[T]
Length:	200	[mm]
Free aperture diameter, Di:	76	[mm]
Outer diameter yoke, Do:	≤ 480	[mm]
Yoke material:	XC06	[-]

MAGNETIC FIELD QUALITY:

Good field radius, GFR	20	[mm]
Integrated field homogeneity, GFR: $\Delta B_z dz(r) / B_z dz(0) $	< 5x10 ⁻³	

COIL DATA:

Conductor type:	Hollow conductor	[-]
Impregnation system:	DF3C	[-]
Conductor dimensions:	7.0*7.0 / bore ø 4.0	[mm]
Number of conductor layers:	12	[-]
Number of conductor turns per layer:	25	[-]
Total number of turns in solenoid N _{tot} :	300	[-]
Cooling type:	Water cooled	[-]
Cooling water pressure drop:	5	[bar]
Cooling water flow:	4.2	[l/min.]
Cooling water inlet temperature:	25	[°C]
Cooling water temperature rise:	13.3	[°C]

INTERFACE DATA:

Current, I:	192.2	[A]
Voltage complete magnet, U:	20.2	[V]
Power, complete magnet, P:	3.9	[kW]
Proposed power supply, output current, I _{PS} :	200	[A]
Proposed power supply, output voltage, U _{PS} :	60	[V]
Proposed power supply, output power, P _{PS} :	12	[kW]

GENERAL DATA:

Total magnet weight, W _{tot} :	120	[kg]
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VACUUM CHAMBER:

Included/excluded:	Optional	[-]
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MAGNET SUPPORT:

Aluminium alloy support plate attached underneath the magnet with 3 tapped holes M24*1.5mm pitch for adjustment screw	Optional	[-]
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ALIGNMENT FACILITIES:

Alignment facilities included/excluded:	Included	[-]
Type:	to be agreed upon	[-]

OTHER ACCESSORIES:

Flow switch included/excluded:	To be discussed	[-]
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Beam transport device – Solenoid (NC)



IDX co.,Ltd.
Tel: +81-283-85-7200
Fax: +81-283-85-7272
E-mail: info@idx-net.co.jp
URL: www.idx-net.co.jp/

Quotation No: 00013030
To : Inter-University Accelerator Center
Aruna Asaf Ali Marg Near Vasant Kunj New Delhi, 110067 INDIA

Date: 11 November 2015

Budgetary estimate obtained for the solenoid

Quotation

Item	Description	Quantity	Unit Price (US\$)	Total Price (US\$)
1	Solenoid electromagnet (MODEL No : ISM-51.3kk)	1	\$29,280.00	\$29,280.00
2	Packing costs, Transport costs	1	\$4,067.00	\$4,067.00
3	Insurance	1	\$342.00	\$342.00
Total				\$33,689.00

Terms:

1. Payment Terms : A/P(Advance Payment) or through discussion.
2. This quotation is valid for 30 days.
3. Delivery time : 5.5 months after order.
4. If currency exchange rates fluctuates by $\pm 3\%$, the rate will be re-negotiated and determined separately.
5. The total price excludes customs duties.
6. No warranty for this product.


Shigeo Kowada

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IDX co.,Ltd.
2946 Machiya-cho, Sano-shi Tochigi 327-0812 Japan